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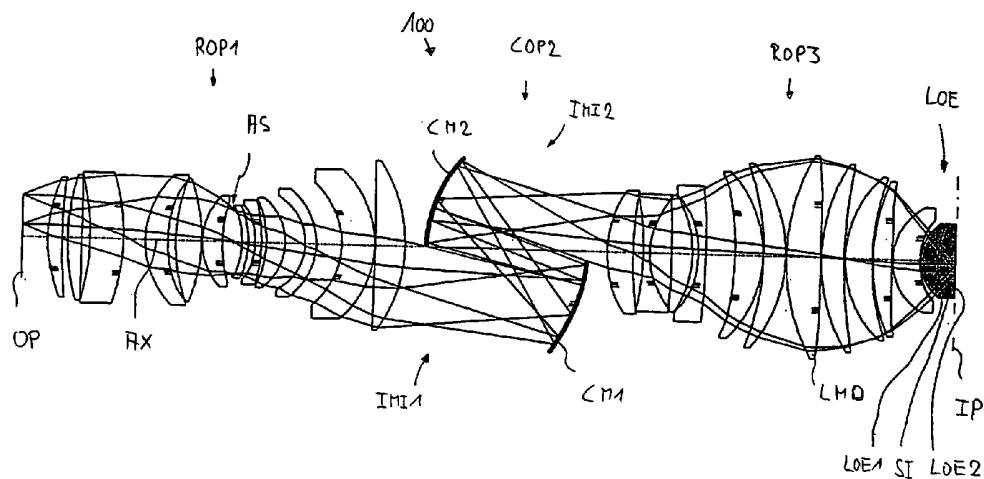
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(54) Title: PROJECTION OBJECTIVE HAVING A HIGH APERTURE AND A PLANAR END SURFACE



(57) Abstract: A projection objective for imaging a pattern provided in an object plane (OP) of the projection objective onto an image plane (IP) of the projection objective suitable for microlithography projection exposure machines has a plurality of optical elements transparent for radiation at an operating wavelength of the projection objective. At least one optical element (LOE1, LOE2) is a high-index optical element made from a high-index material with a refractive index $n \geq 1.6$ at the operating wavelength.

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Projection objective having a high aperture and a planar end surface

BACKGROUND OF THE INVENTION

5 Field of the invention

The present invention relates to a projection objective for imaging a pattern provided in an object plane of the projection objective onto an image plane of the projection objective. The projection objective may be 10 used for microlithography projection exposure machines. The invention relates, in particular, to exposure machines for semiconductor structures which are designed for immersion operation, that is to say in an aperture range where the image side numerical aperture NA is greater than 1.0.

15 Description of the Related Art

In the case of reducing optical imaging, in particular of projection lithography, the image side numerical aperture NA is limited by the refractive index of the surrounding medium in image space. In immersion lithography the theoretically possible numerical aperture NA is limited by the refractive index of the immersion medium. The immersion medium can 20 be a liquid or a solid. Solid immersion is also spoken of in the latter case.

However, for practical reasons the aperture should not come arbitrarily 25 close to the refractive index of the last medium (i.e. the medium closest to the image), since the propagation angles then become very large relative to the optical axis. It has proven to be practical for the aperture not substantially to exceed approximately 95% of the refractive index of the last medium of the image side. This corresponds to propagation 30 angles of approximately 72° relative to the optical axis. For 193 nm, this corresponds to a numerical aperture of $NA = 1.35$ in the case of water ($n_{H2O} = 1.43$) as immersion medium.

With liquids whose refractive index is higher than that of the material of the last lens, or in the case of solid immersion, the material of the last lens element (i.e. the last optical element of the projection objective 5 adjacent to the image) acts as a limitation if the design of the last end surface (exit surface of the projection objective) is to be planar or only weakly curved. The planar design is advantageous, for example, for measuring the distance between wafer and objective, for hydrodynamic behaviour of the immersion medium between the wafer to be exposed 10 and the last objective surface, and for their cleaning. The last end surface must be of planar design for solid immersion, in particular, in order to expose the wafer, which is likewise planar.

For DUV (operating wavelength of 248 nm or 193 nm), the materials 15 normally used for the last lens are fused silica (synthetic quartz glass, SiO_2) with a refractive index of $n_{\text{SiO}_2} = 1.56$ or CaF_2 with a refractive index of $n_{\text{CaF}_2} = 1.50$. The synthetic quartz glass material will also be referred to simply as "quartz" in the following. Because of the high 20 radiation load in the last lens elements, at 193 nm calcium fluoride is preferred for the last lens, in particular, since synthetic quartz glass would be damaged in the long term by the radiation load. This results in a numerical aperture of approximately 1.425 (95% of $n = 1.5$) which can be achieved. If the disadvantage of the radiation damage is accepted, 25 quartz glass still allows numerical apertures of 1.48 (corresponding to approximately 95% of the refractive index of quartz at 193 nm). The relationships are similar at 248 nm.

SUMMARY OF THE INVENTION

30 One object of the invention is to provide a high-aperture projection objective which circumvents the disadvantages of conventional designs with immersion media such as water or with lens materials such as

fused silica and CaF_2 . It is another object of the invention to provide projection objectives suitable for immersion lithography at image side numerical apertures of at least $\text{NA} = 1.35$ having moderate size and material consumption.

5

As a solution to this and other objects, this invention, according to one formulation, provides a projection objective for imaging a pattern provided in an object plane of the projection objective onto an image plane of the projection objective suitable for microlithography projection

10 exposure machines comprising: a plurality of optical elements transparent for radiation at an operating wavelength of the projection objective; wherein at least one optical element is a high-index optical element made from a high-index material with a refractive index $n \geq 1.6$ at the operating wavelength.

15

One embodiment consists in a radiation-proof lithography objective with image side numerical apertures which are preferably greater than or equal to $\text{NA} = 1.35$ and for which at least the last lens element consists of a high-index material (refractive index $n > 1.6$, in particular $n > 1.8$). In

20 the case of the reduction ratio, customary in lithography, of (absolute) 4:1 ($|\beta| = 0.25$), the object-side (mask-side) numerical aperture is then $\text{NA}_{\text{obj}} \geq 0.33$, preferably $\text{NA}_{\text{obj}} \geq 0.36$.

Various aspects of the invention are explained below in more detail
25 using exemplary embodiments for 193 nm. In the examples, a material used for the last lens element or a part thereof is sapphire (Al_2O_3), while the remaining lenses are made from fused silica. However, the examples can be transferred to other high-index lens materials and other wavelengths. For example, for 248 nm it is possible to use Germanium
30 dioxide (GeO_2) as material for the last lens or a part thereof. By contrast with sapphire, this material has the advantage that it is not birefringent. However, the material is no longer transparent at 193 nm.

In the case of liquid immersion, an $NA > 1.35$ may be reached if an immersion liquid with a higher refractive index than water is used. Cyclohexane (refractive index $n=1.556$) was used in some application examples.

Immersion media with $n>1.6$ are currently regarded as realistic.

If an immersion liquid is used, the thickness of the high-index liquid, that is to say the immersion liquid, can preferably be between 0.1 and 10 mm. Smaller thicknesses within this range may be advantageous since the high-index immersion media generally also exhibit a higher absorption.

15 In preferred embodiments, the projection objective has a last optical element closest to the image plane where that last optical element is at least partly made of a high-index material with refractive index $n > 1.6$. In this case, the image-side numerical aperture NA may be extended close to the refractive index of the high-index material in certain cases. The 20 last optical element may be a monolytic plano-convex lens made of the high-index material. In other embodiments, the last optical element consists of at least two optical elements in optical contact with each other along a splitting interface, where at least one of the optical elements forming the last optical element consists of a high-index 25 material with refractive index $n > 1.6$. Further degrees of freedom for the design may be obtained by using such a plano-convex composite lens.

The composite last optical element may have an entry-side plano-convex lens element having a curved entry surface and a planar exit 30 surface and an exit-side plane parallel plate in optical contact with the plano-convex lens element along a planar splitting surface.

In other embodiments the last optical element includes a plano-convex composite lens having an image-side plano-convex second lens element having a curved entry surface and an essentially planar exit surface, and an object-side first lens element having a curved entry surface and a

5 curved exit surface in optical contact with the curved entry surface of the first lens element. A curved splitting surface is obtained this way. Preferably, a first curvature radius R_1 of the curved entry surface of the first lens element is larger than a second curvature radius R_2 of the entry surface of the second lens element. A reduction in field dependent

10 aberrations can be obtained this way. The first lens element may have a first refractive index n_1 which is smaller than the second refractive index n_2 of the second lens element such that the condition $\Delta n \geq 0.25$ holds for a refractive index difference $\Delta n = n_2 - n_1$. A stepwise increase of refractive index in light propagation direction is thereby obtained close to

15 the image surface.

A high-index crystalline material is preferably used for the second lens element positioned on the image-side, whereas the first lens element (on the object-side) is preferably made from a glassy material. The

20 crystalline material may be chosen from the group consisting of aluminum oxide (Al_2O_3), beryllium oxide (BeO), magnesium aluminum oxide ($MgAlO_4$, spinell), magnesium oxide (MgO), yttrium aluminum oxide ($Y_3Al_5O_{12}$), yttrium oxide (Y_2O_3) and lanthanum fluoride (LaF_3). Silicon dioxide (fused silica, SiO_2) is preferably used for the first lens

25 element.

The first and second lens element may be optically contacted by wringing. However, problems due to differences in thermal expansion coefficients of the first and second lens element may arise at an

30 interface formed by wringing. Therefore, in some embodiments, an immersion medium having refractive index n_i is disposed in a gap between the exit surface of the first lens element and the entry surface

of the second lens element, whereby these lens elements can be mechanically decoupled. Immersion liquids having a refractive index in the range $1.3 \leq n_l \leq 1.6$ may be used for that purpose. A small gap width may be preferable such that a maximum gap width GW in the range 50

5 $\mu\text{m} \leq GW \leq 2 \text{ mm}$ is obtained. Here, the gap width is defined for each point on the curved entry surface of the second lens element as the minimum distance to a corresponding point on the exit surface of the first lens element.

10 In some embodiments designed for very high image-side numerical apertures $NA \geq 1.6$, e.g. with $1.7 \leq NA \leq 1.8$ it has been found beneficial if the last optical element includes a hyper-hemispherical lens having a curved entry surface with curvature radius R2, an essentially planar exit surface, and an axial lens thickness T defined as a distance between the
15 entry surface and the exit surface measured along the optical axis of the lens, where $T > R2$. In this case, the center of curvature of the entry surface lies within the lens at a distance $T - R2$ from the exit surface. The shape of the hyper-hemispherical lens may be a combination of a hemispherical section and a cylindrical section having a radius equal to
20 the radius of curvature of the hemispherical section. In other embodiments, the hyper hemispherical lens has a spherical entry surface extending spherically beyond a central section plane through the center of curvature of the spherical entry surface and aligned perpendicular to the optical axis of the lens. Such lens may be
25 manufactured in a two-step process, where the first step includes forming a sphere from the desired lens material, e.g. a crystalline material having $NA > 1.6$, and a second step of forming a planar exit surface on that lens element by removing a spherical calotte from that sphere, e.g. by cutting. The hyper-hemispherical lens may be used to form the
30 image-side second lens element of a composite plano-convex last optical element described above.

In some embodiments, particularly where a very high image-side numerical aperture such as $NA = 1.5$ or above is desired, it has been found useful to have a spatially dense sequence of aspheric lens surfaces in selected regions of the projection objective, e.g. close to the

- 5 object surface and/or close to the image surface. To that end, preferred embodiments of projection objectives include at least one aspheric lens group consisting of a number N_{ASPL} of at least two immediately consecutive aspheric lenses providing a number N_{ASP} of aspheric lens surfaces, where the condition $AR > 1$ holds for an asphere ratio $AR =$
- 10 N_{ASP}/N_{ASPL} . With other words: within an aspheric lens group obeying this condition, the number of aspheric surfaces is higher than the number of aspheric lenses. As a consequence, at least one "double asphere" is formed within the aspheric lens group. The term "double asphere" as used here describes a situation where two aspherical lens surfaces are
- 15 directly following each other along the optical path. The double asphere may be formed by facing aspherical surfaces of two separate, neighbouring lenses or by a double aspherical lens (biasphere) where both lens surfaces are aspherical surfaces. The aspheric lens group may also include at least one triple asphere (three immediately consecutive
- 20 aspherical surfaces), or higher order multiple aspheres where e.g. 4, 5, 6 or more immediately consecutive aspherical surfaces may be present.

In some embodiments exactly one spherical surface may be present within an aspheric lens group such that a sequence aspheric – spheric –

- 25 aspheric is formed within that aspheric lens group. In these cases, the condition $N_{ASP} = 2 \cdot N_{ASPL} - 1$ is fulfilled. Depending on requirements, the number of aspherical lenses N_{ASPL} may be two or three or four or five, for example. Due to the high spatial density of aspheric surfaces within the aspheric lens group, the aspheric lens group will also be
- 30 denoted "high aperture density lens group" or "HADLG" in the following.

An image-side aspheric lens group with high aspheric density (HADLG) may be arranged immediately upstream of the last optical element, i.e. optically close to the image surface. The aspherical lens surfaces of the aspheric lens group may be designed such that the correction of

5 spherical aberration and oblique spherical aberration (tangential and sagittal) may be effected and at the same time the sine condition is essentially fulfilled for a large aperture. At least one double asphere is preferably provided, where more preferably at least three or at least four immediately consecutive aspheric lens surfaces are provided

10 immediately upstream of the last optical element.

Further, it may be desirable to provide an object-side aspheric lens group arranged immediately downstream of the object-surface and designed as a high aspheric density lens group as described above. The

15 aspheric surfaces may be designed particularly to correct for distortion and to provide object-side telecentricity at high entry-side numerical apertures. Preferably, at least three consecutive aspheric lens surfaces may be provided, where four or more consecutive aspheric lens surfaces may be useful to correct for very complex wavefront deformations having

20 short periodicity in a pupil surface.

The previous and other properties can be seen not only in the claims but also in the description and the drawings, wherein individual characteristics may be used either alone or in sub-combinations as an embodiment of the invention and in other areas and may individually represent advantageous and patentable embodiments.

BRIEF DESCRIPTION OF THE DRAWINGS

30 Fig. 1 is a longitudinally sectioned view of a first embodiment of a catadioptric projection objective according to the invention;

Fig. 2 is a longitudinally sectioned view of a second embodiment of a catadioptric projection objective according to the invention;

5 Fig. 3 is a longitudinally sectioned view of a third embodiment of a catadioptric projection objective according to the invention;

Fig. 4 is a longitudinally sectioned view of a fourth embodiment of a catadioptric projection objective according to the invention;

10 Fig. 5 is a longitudinally sectioned view of a fifth embodiment of a catadioptric projection objective according to the invention;

Fig. 6 is a longitudinally sectioned view of a sixth embodiment of a catadioptric projection objective according to the invention;

15 Fig. 7 is a longitudinally sectioned view of a seventh embodiment of a catadioptric projection objective according to the invention;

20 Fig. 8 is a longitudinally sectioned view of an eigth embodiment of a catadioptric projection objective according to the invention;

Fig. 9 is an enlarged detail illustration of the image-side end section of the projection objective in Fig. 6; and

25 Fig. 10 is a schematic drawing of a last optical element including a hyper-hemispherical crystalline lens and an immersion layer.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

30 In the following description of preferred embodiments of the invention, the term "optical axis" shall refer to a straight line or sequence of straight-line segments passing through the centers of curvature of the

optical elements involved. The optical axis can be folded by folding mirrors (deflecting mirrors). In the case of those examples presented here, the object involved is either a mask (reticle) bearing the pattern of an integrated circuit or some other pattern, for example, a grating

5 pattern. In the examples presented here, the image of the object is projected onto a wafer serving as a substrate that is coated with a layer of photoresist, although other types of substrate, such as components of liquid-crystal displays or substrates for optical gratings, are also feasible.

10 Where tables are provided to disclose the specification of a design shown in a figure, the table or tables are designated by the same numbers as the respective figures.

Fig. 1 shows a first embodiment of a catadioptric projection objective

15 100 according to the invention designed for ca. 193 nm UV working wavelength. It is designed to project an image of a pattern on a reticle (or mask) arranged in the object plane OP into the image plane IP on a reduced scale, for example, 4:1, while creating exactly two real intermediate images IMI1 and IMI2. A first refractive objective part ROP1 is

20 designed for imaging the pattern in the object plane into the first intermediate image IMI1, a second, catoptric (purely reflective) objective part COP2 images the first intermediate image IMI1 into the second intermediate image IMI2 at a magnification close to 1:1, and a third, refractive objective part ROP3 images the second intermediate image

25 IMI2 onto the image plane IP with a strong reduction ratio. The second objective part COP2 comprises a first concave mirror CM1 having the concave mirror surface facing the object side, and a second concave mirror CM2 having the concave mirror surface facing the image side.

The mirror surfaces are both continuous or unbroken, i.e. they do not
30 have a hole or bore. The mirror surfaces facing each other define an intermirror space, enclosed by the curved surfaces defined by the concave mirrors. The intermediate images IMI1, IMI2 are both situated

geometrically inside the intermirror space, at least the paraxial intermediate images being almost in the middle thereof well apart from the mirror surfaces.

- 5 Each mirror surface of a concave mirror defines a "curvature surface" or "surface of curvature" which is a mathematical surface extending beyond the edges of the physical mirror surface and containing the mirror surface. The first and second concave mirrors are parts of rotationally symmetric curvature surfaces having a common axis of rotational symmetry.
- 10

The system 100 is rotational symmetric and has one straight optical axis AX common to all refractive and reflective optical components. There are no folding mirrors. The concave mirrors have small diameters allo-

- 15 wing to bring them close together and rather close to the intermediate images lying in between. The concave mirrors are both constructed and illuminated as off-axis sections of axial symmetric surfaces. The light beam passes by the edges of the concave mirrors facing the optical axis without vignetting.

20

Catadioptric projection objectives having this general construction are disclosed e.g. in the US provisional applications with serial numbers 60/536,248 filed on January 14, 2004, 60/587,504 filed on July 14, 2004 and a subsequent extended application filed on October 13, 2004. The

- 25 contents of these applications is incorporated into this application by reference. It is one characterizing feature of this type of catadioptric projection objectives that pupil surfaces (at axial positions where the chief ray intersects the optical axis) are formed between the object plane and the first intermediate image, between the first and the second
- 30 intermediate image and between the second intermediate image and the image plane and that all concave mirrors are arranged optically remote from a pupil surface, particularly at positions where the chief ray height

of the imaging process exceeds a marginal ray height of the imaging process. Further, it is preferred that at least the first intermediate image is located geometrically within the intermirror space between the first concave mirror and the second concave mirror. Preferably, both the first 5 intermediate image and the second intermediate image are located geometrically within the intermirror space between the concave mirrors.

The exemplary examples described below share these basic characteristics which allow immersion lithography at numerical apertures $NA > 1$ 10 with optical systems that can be built with relatively small amounts of 15 optical material.

Fig. 1 shows as first exemplary embodiment a lithography objective for 193 nm with a sapphire lens and cyclohexane as immersion medium in 20 conjunction with an image-side numerical aperture of $NA = 1.45$. The sapphire lens is the last optical element LOE closest to the image plane. The image-side working distance is 1 mm. The catadioptric design has 25 two concave mirrors, chiefly for chromatic correction and Petzval correction, and an intermediate image respectively upstream and downstream of the pair of mirrors. The intermediate images are, however, not fully corrected and serve primarily for the geometrical limitation of the design and for separating two beam paths running toward a mirror and running from a mirror after reflection therupon. The image field (on the wafer) is rectangular. The external field radius (on the wafer side) is 15.5 mm, the inner one 4.65 mm. The result of this is a rectangular field of 26 x 3.8 mm.

The aperture diaphragm (aperture stop AS, system aperture) is arranged 30 in the first refractive objective part ROP1 in the first exemplary embodiment. This is advantageous in order, on the one hand, to fashion a smaller variable aperture diaphragm, and on the other hand largely to protect the subsequent objective parts (seen from the object plane

(mask plane)) against useless and interfering radiation loads when stopping down the aperture diaphragm. The rear diaphragm plane in the image-side objective part ROP3, i.e. a position where an aperture stop could be placed, is positioned in a region between the lens of maximum 5 diameter LMD and the image plane IP in the convergent beam path.

Formed in the object-side front refractive partial objective ROP1 is a waist (constriction of the beam and lens diameters) which serves primarily for correcting the image field curvature (Petzval sum). The 10 aperture stop AS is arranged at the waist.

The use of CaF_2 for the last lens is not to be preferred, since this requires a numerical aperture that is as far as possible not greater than 1.425 (~95% of the refractive index of CaF_2). At 193 nm, sapphire 15 (Al_2O_3) is used in this example as high-index material in the last lens element LOE. In all embodiments shown in the figures optical elements made of sapphire are shaded gray for easier reference.

The birefringence occurring when sapphire is used is largely compensated by splitting the last lens (last optical element LOE) into two lens elements LOE1 and LOE2 and rotating the two lens elements relative to one another around the optical axis. In this case, the separation interface SI (contact surface of the two lens elements LOE1 and LOE2) is preferably curved such that both lens elements have 25 similar refractive power. Alternatively, it is possible to use for the compensation a second element made from sapphire which is located at a site in the objective which acts similarly in optical terms, for example in the vicinity of the intermediate images or in the vicinity of the object plane. In the present case, the last sapphire lens LOE is split into two 30 lens elements LOE1 and LOE2 which act virtually identically. The front radius of the sapphire lens LOE (i.e. the radius of the light entry side) is designed such that an aperture beam, i.e. a beam running towards the

image at the perimeter of the convergent light bundle, toward the center of the image field passes through the interface virtually without being refracted, that is to say strikes the interface virtually perpendicularly (lens radius is virtually concentric with the point of intersection of the 5 image plane with the optical axis). The radius of the splitting interface SI between the two lens elements of the split sapphire lens is flatter (radius > 1.3 times the distance from the image plane where a wafer can be placed).

10 Compensation of birefringence effects by relative rotation of elements made of birefringent material is described in detail e.g. in patent applications DE 101 23 725 A1 (corresponding e.g. to US 2004/0190151 A1) or WO 03/077007 A2 by the applicant. Catadioptric projection objectives having a final lens element closest to the image plane designed as a 15 split final lens made from a birefringent material (calcium fluoride) are known from US 6,717,722 B.

The specifications for the design of Fig. 1 are summarized in Table 1. The leftmost column lists the number of the refractive, reflective, or 20 otherwise designated surface, the second column lists the radius, r , of that surface [mm], the third column lists the distance, d [mm], between that surface and the next surface, a parameter that is referred to as the "thickness" of the optical element, the fourth column lists the material employed for fabricating that optical element, and the fifth column lists 25 the refractive index of the material employed for its fabrication. The sixth column lists the optically utilizable, clear, semi diameter [mm] of the optical component. In the tables, a radius value $r=0$ is given for planar surfaces having infinite radius.

30 In the case of this particular embodiment, fifteen surfaces are aspherical surfaces. Table 1A lists the associated data for those aspherical surfa-

ces, from which the sagitta of their surface figures as a function of the height h may be computed employing the following equation:

$$p(h) = [((1/r)h^2)/(1 + \text{SQRT}(1 - (1 + K)(1/r)^2h^2))] + C1 \cdot h^4 + C2 \cdot h^6 + \dots,$$

5

where the reciprocal value $(1/r)$ of the radius is the curvature of the surface in question at the surface vertex and h is the distance of a point thereon from the optical axis. The sagitta $p(h)$ thus represents the distance of that point from the vertex of the surface in question, measured along the z -direction, i.e., along the optical axis. The constants K , $C1$, $C2$, etc., are listed in Table 1A.

10

Likewise, the specifications of the following embodiments are represented in similar manner in tables 2, 2A for Fig. 2, tables 3, 3A for Fig. 3, 15 tables 4, 4A for Fig. 4 and tables 5, 5A for Fig. 5.

In accordance with the projection objective 200 according to Fig. 2 the last optical element LOE on the image side has the overall shape of a plano-convex lens. The lens is subdivided into two optical elements LOE1

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and LOE2 which are contacted along a plane splitting interface SI. Specifically, a quartz glass lens LOE1 with a positive radius of curvature of the entry surface and a rear planar surface is wrung onto one (or two) plane-parallel plates LOE2 made from sapphire. This yields values of NA

no higher than possible in quartz glass, but there is the advantage that

25

the angle of propagation of the light beams is reduced in the last objective part where the aperture is greatest owing to the high-index medium. This is advantageous when considering the reflection losses and scattered light effects at the interface and at possible protective layers on the last end surface, which constitute a problem for these

30

otherwise very large angles of propagation. The largest angles then occur only at the wrung surface between the quartz lens LOE1 and the first high-index plane-parallel plate LOE2. This wrung surface (contact

interface where the adjacent optical elements are adhered to each other by wringing) is protected against contamination and damage, and can be designed with a coating which is sensitive to environmental influences as well. If two plane-parallel plates are used to form the plane-parallel

5 high-index element LOE2, then the two plane-parallel plates made from sapphire can be rotated relative to one another around the optical axis virtually ideally to compensate the birefringence effect for the S- and P-polarisations in the x- and y-directions which are chiefly required for imaging the semiconductor structures.

10

However, because of its lower refractive index, the quartz lens LOE1 has the effect here that – because of its lesser collecting effect – very large lens diameters are required even for image-side numerical apertures of a projection objective of limited overall length which are not

15 really so large. In the second exemplary embodiment (Fig. 2), the aperture is $NA = 1.35$, but the lens diameters are greater than in the first exemplary embodiment. Here, the lens diameter is already over 143 mm and thus virtually 212 times the numerical aperture, while in the exemplary embodiment in Fig. 1 only 200 times the numerical aperture is

20 reached. In particular, in the exemplary embodiment in Fig. 2 at 143 mm the maximum half lens diameter is even greater than the mirror semi-diameter at approximately 136 mm.

In order to minimize the diameter of the largest lens elements of the

25 projection objective, and at the same time to minimize the effect of the birefringence, in an alternative embodiment (projection objective 300) of the design example with $NA = 1.45$ the last lens element LOE comprises a thin sapphire lens LOE1 with positive refractive power, a spherically curved entry surface and a planar exit surface, which is wrung onto a

30 thin quartz glass plate LOE2 (exemplary embodiment 3 in Fig. 3). The plane-parallel quartz glass plate providing the exit surface of the objective can then be interchanged upon the occurrence of damage

owing to the radiation load. A wrung quartz plate therefore also acts as interchangeable protection of the sapphire lens LOE1 against contamination and/or scratches or destruction. Embodiment 3 is adapted to Cyclohexane as an immersion fluid, which has a refractive index 5 ($n = 1.556$) similar to that of fused silica ($n = 1.560$) used for the plate in contact with the immersion fluid.

In these cases, the NA is limited by the refractive index of the quartz glass. However, by comparison with a design having a last lens made 10 from pure quartz glass the result upstream of the last lens is smaller beam angles and therefore also smaller diameters of the overall objective and lower sensitivities (interference susceptibilities to manufacturing tolerances) of the last lens element. In embodiment 3, at 135 mm the maximum lens diameter is now approximately 186 times the 15 numerical aperture.

Of course, the present invention can also be used for objectives of low numerical aperture, in order to reduce substantially the diameter of previous projection objectives. This advantageously affects the price of 20 the projection objective, since the amount of material can be reduced substantially.

The exemplary fourth embodiment (Fig. 4) shows a lithography objective 400 for 193 nm with a monolithic last lens made of sapphire and water 25 ($n_{H2O} = 1.43$) as immersion medium for $NA = 1.35$ with a working distance of 1 mm. The top side (entrance side) of the monolithic (one part, not split) sapphire lens LOE is aspheric, and the aperture stop AS is situated in the rear part of the image side refractive objective part ROP3 in the region of convergent radiation between the region of largest 30 beam diameter in the third objective part ROP3 at biconvex lens LMD with largest diameter and the image plane IP. The maximum lens diameter is limited to less than 190 times the numerical aperture.

Even higher numerical apertures than $NA = 1.45$ are possible with the aid of high-index materials for at least the last lens element.

- 5 The fifth exemplary embodiment 500 (Fig. 5) is designed for solid immersion (contact projection lithography) with a plano-convex sapphire lens LOE ($n_{\text{sapphire}} = 1.92$) for an $NA = 1.6$. Consequently, even numerical apertures of up to $NA > 1.8$ are feasible in principle. In the example, the outer field radius on the wafer side is at 15.53 mm, and the
- 10 inner one is at 5.5 mm, that is to say the size of the rectangular field here is 26 x 3 mm.

Since the high-aperture beams with apertures of $NA > 0.52$ experience total reflection upon transition from sapphire to air at the plane exit surface, working distances of less than the wavelength must be realized for solid immersion in order to efficiently use evanescent waves for the exposure of the wafer. This can be performed in vacuo by bringing the wafer to be exposed constantly to, for example, 100 nm ($\approx \lambda/2$) in the vicinity of the last lens surface.

20

However, since on the basis of the power transmission, which drops exponentially with distance, through evanescent fields small changes in distance result in strong fluctuations in uniformity, it is advantageous to bring the wafer into direct mechanical contact with the last end surface (exit surface) of the projection objective. To be exposed, the wafer can be wrung onto the last planar lens surface (contact surface CS) for this purpose in order to obtain a mechanical contact between the exit surface of the projection objective and the incoupling surface associated to the substrate. A step-and-scan mode or stitching methods of exposure is to

25 be preferred in this case, that is to say larger regions than the image field are exposed in individual steps, the reticle mask being correspondingly adjusted for alignment instead of, as previously

30

customary, the wafer. This is also advantageous because owing to the reducing imaging the reticle can be adjusted with less accuracy than an adjustment of the wafer. Mutually adjoining exposure regions (target areas) or sequential levels of the semiconductor structure from 5 subsequent exposure steps are thereby brought into overlay by lateral and axial movement and rotation of the reticle mask in order thereby to expose the semiconductor structures onto the possibly also defectively wrung wafers with an overlay accuracy of better than a few nm. Alignment marks, for example, of the reticle are brought into agreement 10 for this purpose with alignment marks already exposed on the wafer.

The release of the wafer from the last surface is preferably performed in vacuo. If required, there is located between the wafer and last planar lens surface a thin layer (pellicle/membrane) which can be exchanged 15 after each exposure step, for example. This membrane can, for example, also remain bonded on the wafer and assist in the separation and serves, in particular, as protection for the last planar lens surface. The latter can optionally be protected in addition by a thin protective layer.

20 In the case of solid immersion, standing waves of high intensity can be produced during the exposure in the edge region of the last lens surface owing to the instances of imaging interference. It is therefore even advantageous for the repeated exposure of a structure onto a wafer when the wafer is inaccurately positioned by chance in certain ranges of 25 a few micrometers owing to the wringing, something which is compensated by adjustment using the reticle in order to prevent systematic structures from being burnt into the last lens.

If it is desired to obtain resolutions at the 32nm-node at 193 nm image- 30 side numerical apertures $1,7 \leq NA \leq 1,75$ are desireable. Typical resist materials available for that wavelength have refractive indices in that range, i.e. $1,7 \leq n \leq 1,75$. If resist materials with high index close to $n =$

1,75 can be used, sufficient light energy can be coupled into the resist material at e.g. NA = 1,73 using immersion techniques or projection across the optical near field. In the following, technical measures are presented which contribute to obtaining NA values in the desired range,

5 particularly for catadioptric in-line projection objectives exemplarily shown above.

One contribution for obtaining very high NA is concerned with improving the construction of the last optical element in order to accommodate

10 extremely high aperture angles. Another contribution concerns the use of aspheric lens surfaces within the optical system.

Fig. 6 shows a meridional lens section of a sixth exemplary embodiment of a projection objective 600 designed for microlithography at 193 nm at

15 an image-side working distance of 1 mm and having an image-side numerical aperture NA = 1,73 at an image field size 4 mm • 20 mm, where the off-axis rectangular image field lies at a distance 4,375 mm outside the optical axis. The track length (axial distance between object plane and image plane) is 1308,7 mm. The optical correction for

20 aberrations is characterized by a wavefront error (RMS) smaller than 7,0 mλ. The optical element closest to the image plane (see detail in Fig. 9) is made of sapphire, where the crystallographic axis CA of the optically uniaxial material is aligned parallel to the optical axis of the lens element. In the optical calculations, the refractive index of the ordinary

25 beam (n_o) is used in connection with tangential polarization of the projection radiation. The specification is given in tables 6, 6A.

One problem addressed in this embodiment is the radius of curvature (curvature radius) of the entry surface of the last optical element, which

30 should be quite short to accommodate a high NA without causing intolerable aberrations. In relation to the desired size of the image field a longer curvature radius would be desireable to avoid or minimize field

dependent aberrations. Providing a larger curvature radius, however, would require a large thickness of the last optical element (where the thickness is the axial distance between the entry side of a lens and the exit side of a lens measured along the optical axis). In order to address 5 these problems, the last optical element LOE of the embodiment is a plano-convex composite lens having an image-side plano-convex second lens element LOE2 having a curved entry surface and an essentially planar exit surface and an object-side first lens element LOE1 having a curved entry surface and a curved exit surface in optical 10 contact with the curved entry surface of the second lens element LOE2. The first curvature radius R1 of the curved entry surface of the first lens element LOE1 is larger than the second curvature radius R2 of the entry surface of the second lens element LOE2. Whereas the second lens element LOE2 closest to the image plane is made of sapphire having a 15 high first refractive index $n_2 = 1.92$, the first lens element is made of fused silica having a smaller first refractive index $n_1 = 1.52$ such that a refractive index difference $\Delta n = n_2 - n_1 = 0.40$. In this configuration, the convex entry surface on the first lens element LOE1 with longer radius provides partly the corrective effect which a longer radius of the second 20 optical element LOE2 would have had.

Different ways of contacting the first and second lens element of the last optical element along their curved contacting surfaces are possible. In an embodiment (not shown) the lens elements are contacted by 25 wringing. However, problems may arise due to a difference in thermal expansion coefficient between the crystalline material of the image-side second lens element and the glassy material of the object-side first element. The thermal expansion coefficient of fused silica is about $0,52 \cdot 10^{-6}$ m/K. In contrast, the thermal expansion coefficient of suitable 30 crystalline materials is much higher, typically by a factor of at least 10. The following table lists a number of suitable crystalline materials transparent at 193 nm (left column) and their respective linear thermal

expansion coefficients β_{\parallel} parallel to the crystallographic axis (middle column) and β_{\perp} perpendicular to the crystallographic axis (right column) in terms of 10^{-6} m/K.

Material	$\beta_{\parallel} [10^{-6} \text{ m/K}]$	$\beta_{\perp} [10^{-6} \text{ m/K}]$
Al_2O_3	6,65	7,15
BeO	5,64	7,47
MgAlO_4	6,97	9,4
MgO	10,6	10,6
$\text{Y}_3\text{Al}_5\text{O}_{12}$	7,7	7,7
Y_2O_3	6,56	6,56
LaF_3	15,8	11,0

5

In view of the differences in thermal expansion, an immersion medium having a refractive index n_l is disposed in a gap (gap width $GW=0.2$ mm) between the exit surface of the first lens element and the entry surface 10 of the second lens element such that the optical contact is provided through the immersion liquid IL. Preferably $1,3 \leq n_l \leq 1,6$, in the embodiment $n_l = 1.561$. It has been found that a plano-convex composite lens including an object-side negativ meniscus having image-side concave surface made from a glassy material, and an image-side 15 plano-convex lens element made from a high-index crystalline material having a refractive index difference of at least $\Delta n = 0.25$ optically contacted by an immersion liquid is capable of transporting very high numerical apertures, such as $NA > 1,6$ or $NA > 1,7$ without inducing significant aberration contributions. Such composite lens may be used in 20 any type of projection objective capable of providing image-side numerical apertures in that range.

Residual aberrations may be left. Particularly, correction of spherical aberration and oblique spherical aberration (tangential and sagittal) in

conjunction with obeying the sine condition impose a serious challenge. It has been found that it may be beneficial to provide a large spatial density of aspheric surfaces close to the last optical element particularly to obtain a magnification factor which is essentially constant across the

5 image field. To that end, an image-side aspherical lens group ALGI is arranged immediately upstream of the last optical element LOE consisting of two positive meniscus lenses having image-side concave surfaces, where each of that lenses is a "biasphere" having aspheric entry and exit surface such that four immediately consecutive aspheric

10 lens surfaces are provided immediately upstream of the last optical element LOE. With $N_{ASPL} = 2$ and $N_{ASP} = 4$, the asphere ratio $AR = 2$. In other embodiments, three out of four lens surfaces immediately upstream of the last optical element are aspheric.

15 Other aberration problems are to be solved on the object-side of the projection objective, where the design of lenses immediately downstream of the object plane is optimized to provide object-side telecentricity and very low level of distortion. The entry side part of the first refractive objective part ROP1 arranged between object plane and

20 the first pupil surface P1 (where the chief ray CR intersects the optical axis AX) is functionally subdivided into three groups G1, G2, G3, where each group consists of one or more lenses. No negative lenses are provided upstream of the aperture stop. A first group G1 is formed by two positive biaspherical meniscus lenses, where the curvature radius of

25 the local curvature at the vertex and outside the optical axis are on the image-side primarily to secure object-side telecentricity. The second group G2, formed by one single positive lens G2 having aspherical entry sine and spherical exit side, is designed such that the center of curvature of local radii of curvature are on the object-side at least for the

30 outer parts of the lens surfaces at more than 70 % of the maximum height. In the case of aspherical lens surfaces, it is prefered that the local curvature increases substantially towards the edge of the lens for

lens heights beyond 90 % maximum height. Preferably, the radius of curvature R is shortened, or the curvature 1/R is increased from the center (on the optical axis) towards the edge by at least 30 %. An object-side aspheric lens group ALGO having five immediately consecutive 5 aspheric lens surfaces is thereby provided. For smaller apertures four or three consecutive aspherical lens surfaces may be sufficient.

A third group G3 is formed by one positive lens designed primarily for correcting spherical aberrations. Due to the high object-side numerical 10 aperture this correction becomes extremely difficult. Therefore it is preferred to use a biaspherical lens immediately upstream of the first pupil surface where the aperture stop AS is positioned. The refractive power of this lens group is preferably decreasing from the center to the edge of the lens to provide the required amount of spherical 15 overcorrection. Such lenses are preferably positioned at a distance from the aperture stop being less than the diameter of the aperture stop.

A fourth lens group G4 immediately downstream of the first pupil surface P1 is designed as a positive meniscus lens having an object-side 20 concave entry surface, where the thickness of that meniscus lens is preferably less than 60 % of the diameter. One or more meniscus lenses in that region immediately following the first pupil surface may be designed to primarily correct image shell differences and field dependent aberrations. The curvature radius is preferably smaller than 1,2 times the 25 diameter of that lens.

A lens group G5 having overall positive refractive power is provided immediately upstream of the first concave mirror CM1 to converge radiation towards that mirror. Each lens element of the fifth lens group 30 has a mean radius of curvature, $R_M = 1/(1/R_1 + 1/R_2)$ with the center of curvature on the image-side, where R1 and R2 are the radius of curvature of the entry side and exit side of the lens, respectively.

Preferably, the last lens before the first concave mirror CM1 is a biaspheric lens with strong correcting effect.

The second, catoptric (purely reflective) objective part COP2 is formed

5 by two aspheric concave mirrors CM1, CM2 (forming groups G6 and G7, respectively) and serves as an imaging subsystem to image the first intermediate image IMI1 onto the second intermediate image IMI2, which is strongly aberrated.

10 A lens group G8 immediately following the second concave mirror is formed by a single positive meniscus lens having an image-side concave surface. A lens group G9 having four consecutive negative lenses disposed with opposing sense of bending around a biconcave negative lens provides overcorrection for the subsequent positive lenses

15 of the lens group G10, which is designed primarily to provide the high image-side numerical aperture. The mirror symmetry of the bending of positive lenses immediately upstream and downstream of the negative group G9 provides an essentially symmetric distribution of refractive power allowing to minimize asymmetric imaging errors over the field. It

20 has been found that a dense sequence of aspheric lens surfaces within the negative lens group G9 is beneficial for providing the required complex correcting effect of that lens group. Therefore, at least three or at least four consecutive aspheric lens surfaces are considered beneficial in that region. In the embodiment, five consecutive aspheric

25 lens surfaces are provided in a region where large angles of incidence occur, whereby a complex distribution of refractive power across the beam diameter is obtained.

The optical effect of the aperture-providing tenth lens group G10 has

30 already been described above. It is worth to note that spherical lens surfaces appear to be sufficient in the region upstream of the image-side aspherical lens group ALGI. A thin meniscus lens having low refractive

power is provided in the region of largest beam diameter upstream of the third pupil surface P3. For smaller NA values the undercorrecting effect of that lens may be provided by adjacent lenses such that a lens element with large diameter can be omitted.

5

The projection objective 700 in Fig. 7 is a variant of the design of Fig. 6, where the number, type and sequence of lenses and mirrors is essentially the same as in Fig. 6, with the exception of the last optical element LOE. Reference is made to that description in so far. The 10 specification is given in tables 7, 7A. An image-side numerical aperture $NA = 1,75$ is obtained in a rectangular field (4,0 mm x 20 mm) with a wavefront error of $7,0 \text{ m}\lambda$ for 193 nm at track length 1332,2 mm. It is one characterizing feature that the ray height of the upper coma ray COR at the lens element closest to the object plane is essentially the same as 15 the coma ray height at the last lens G3 immediately upstream of the first pupil surface P1 where the aperture stop AS is positioned (maximum height difference 10 %). A third lens group G3 is designed as biaspherical lens to provide spherical overcorrection.

20 The last optical element LOE includes a hyper-hemispherical lens LOE2 having a curved entry surface with curvature radius R_2 and an essentially planar exit surface and an axial lens thickness T defined as the axial distance between the curved entry surface and the exit surface along the optical axis of the lens, where $T > R_2$ (compare Fig. 9). 25 Particularly, T is at least 25 %, preferably at least 30 % or even at least 33 % larger than the curvature radius of the convex entry surface (in the embodiment, T is about 34,7 % larger than R_2). If an immersion layer is used between the last optical element and the substrate surface disposed in the image plane, it is prefered that the thickness of that layer 30 is included in the thickness T . Regarding this aspect, reference is made to US Provisional Application with title "Mikrolithographie-Projektionsobjektiv und Projektionsbelichtungsanlage" filed by the

applicant on March 2, 2005. The disclosure of this application is incorporated herein in its entirety by reference.

Fig. 8 shows a variant of the embodiments of Figs. 6 and 7 with $NA = 5$ 1,75, where the RMS value of the wavefront error has been reduced to less than $4,5 \text{ m}\lambda$. The specification is given in tables 8, 8A. The types and sequence of lenses and mirrors are essentially the same as in the embodiments of Figs. 6 and 7 with one exception on the entry side of the projection objective, where the first lens group G1 is now formed by 10 three (instead of two) meniscus lenses having image-side concave surfaces. Each of the lenses is a biaspherical lens. Including the entry surface of the following positive meniscus G2 seven immediately consecutive aspheric lens surfaces are provided immediately following the object plane. As the subsequent lens G3 immediately upstream of 15 the aperture stop AS is a biaspherical lens, a total of nine aspheric surfaces ($N_{ASP} = 9$) are provided on five consecutive aspheric lenses ($N_{ASPL} = 5$) such that $AR = 1,8$ holds for the object-side aspheric lens group ALGO following the object plane. Using the higher orders of single aspheric parameters and the spatially dense sequence of aspheric 20 surfaces immediately following each other a very complex correcting effect on the wavefront across the diameter of the beam is obtained for various rays. The example also shows that an aspheric lens group may also be sufficiently effective if one spherical surface (e.g. convex exit surface of G2) is present within an aspheric lens group such that $N_{ASP} = 25 2 \cdot N_{ASPL} - 1$.

Another dense sequence of aspheric lens surfaces is provided in the region of the negative lenses of lens group G9 near the constriction region or waist on the entry side of the third refractive objective part 30 ROP3. Here, each of the four negative lenses is an aspheric lens ($N_{ASPL} = 4$), three of that lenses are biaspherical lenses, whereas one lens has one aspheric lens surface only ($N_{ASP} = 7$). Considering that the entry

side of the subsequent first lens of group G10 is also aspheric, there are seven immediately subsequent aspheric lens surfaces in G9 and G10, and in six subsequent aspheric lenses (G8, G9 and first lens of G10) there are nine aspheric lens surfaces ($N_{ASPL} = 9$). Therefore, $AR = 1,5$.

5

Further, three positive meniscus lenses with image-side concave surfaces immediately upstream of the last optical element LOE ($N_{ASPL} = 3$) provide five aspheric lens surfaces ($N_{ASP} = 5$) such that $AR = 1,66$. Further, since the convex entry side of the last optical element is also 10 aspheric, there are six immediately consecutive aspheric lens surfaces close to the image plane.

The mutually facing curved surfaces of the constituent lenses LOE1, LOE2 of the last optical element are spherical. The plano-convex lens 15 element LOE2 is a hyper-hemispherical lens having a spherical entry surface extending spherically beyond a central plane through the center of curvature of the curved entry surface perpendicular to the optical axis (Fig. 10). The lens element is manufactured by first manufacturing a spherical element and by secondly removing a smaller part of the sphere 20 to provide the planar surface forming the exit surface. The planar exit surface is oriented perpendicular to the crystallographic axis CA of the optically uniaxial lens material sapphire. The corresponding spherical exit surface is likewise hyper-hemispherical. The fused silica material is sectioned such that an opening radius A for inserting the crystal lens 25 LOE2 is larger than the radius R2 of the truncated spherical crystal lens LOE2. In the embodiment, an immersion liquid IL is provided in a gap between the mutually facing spherical lens surfaces.

The optimum shape of aspheric lens surfaces in aspheric lens groups 30 having a number of consecutive aspheric surfaces generally differs depending on the position of the aspheric surfaces within the projection objective. Complex correcting effects can be obtained by a dense

sequence of aspheric lens surfaces if the aspheric shapes of the consecutive aspheric surfaces are not uniform, but vary in a specific way within a sequence of aspheric surfaces. In the following, considerations regarding the specific shape of consecutive lens surfaces within 5 aspheric lens groups are presented based on a refined analysis of the embodiments shown in Figs. 6 to 8 having very high image-side numerical apertures, e.g. $NA > 1,6$ and/or $NA \geq 1,7$. The optical calculations were performed with a strictly telecentric input beam on the object side. Therefore an aperture stop was not used for the 10 calculations.

The aspheric shapes are characterized by Zernike coefficients with respect to a spherical reference envelope surface (envelope sphere). Selected parameters defining the Zernike representation with respect to 15 the envelope sphere and the Zernike coefficients for the embodiments shown in Figs 6, 7 and 8 are given in tables 6Z, 7Z, 8Z, respectively, for all aspheric surfaces of the respective projection objectives. The parameters are calculated based on an envelope sphere defined as a mathematical sphere touching the aspheric lens surface at the vertex 20 (on the optical axis) and at the radial outer edge of the optically used area. The optically used area is defined by its diameter $D_{max} = 2 \cdot H_{max}$, where H_{max} [mm] is the maximum height. The envelope sphere has an envelope sphere radius R_{ENV} [mm]. The aspheric lens surfaces are further characterized by the vertex radius R_V [mm], which is the local 25 radius of the aspheric surface on the optical axis, and by the deformation Def [μm], which is defined here as the maximum value of the distance between the envelope sphere and the aspheric surface depending on the height, the deformation being measured parallel to the optical axis.

30 In the representation using Zernike coefficients and Zernike polynomials as used here, the sagitta p of a point on an aspherical surface is

represented as a function of a normalized radial distance h_n from the optical axis according to the following equation:

$$p(h_n) = \frac{h_n^2}{R(1 + \sqrt{1 - \frac{h_n^2}{R^2}})} + K0 + K4 \cdot Z4 + K9 \cdot Z9 + K16 \cdot Z16 + K25 \cdot Z25 +$$

5 $K36 \cdot Z36 + K49 \cdot Z49 + K64 \cdot Z64 + K81 \cdot Z81 + K100 \cdot Z100$

where the radius R of the aspheric lens surface is fixed such that $K4=0$.
 The Zernike polynomials are given in the following equations (where the normalized height h_n is expressed in a simplified manner by parameter h
 10 for reasons of clarity):

$$Z4 = 2 \cdot h^2 - 1$$

$$Z9 = 6 \cdot h^4 - 6 \cdot h^2 + 1$$

15

$$Z16 = 20 \cdot h^6 - 30 \cdot h^4 + 12 \cdot h^2 - 1$$

$$Z25 = 70 \cdot h^8 - 140 \cdot h^6 + 90 \cdot h^4 - 20 \cdot h^2 + 1$$

$$20 \quad Z36 = 252 \cdot h^{10} - 630 \cdot h^8 + 560 \cdot h^6 - 210 \cdot h^4 + 30 \cdot h^2 - 1$$

$$Z49 = 924 \cdot h^{12} - 2772 \cdot h^{10} + 3150 \cdot h^8 - 1680 \cdot h^6 + 420 \cdot h^4 - 42 \cdot h^2 + 1$$

$$Z64 = 3432 \cdot h^{14} - 12012 \cdot h^{12} + 16632 \cdot h^{10} - 11550 \cdot h^8 + 4200 \cdot h^6 - 756 \cdot h^4 + 56 \cdot h^2 - 1$$

25

$$Z81 = 12870 \cdot h^{16} - 51480 \cdot h^{14} + 84084 \cdot h^{12} - 72072 \cdot h^{10} + 34650 \cdot h^8 - 9240 \cdot h^6 + 1260 \cdot h^4 - 72 \cdot h^2 + 1$$

$$Z100 = 48620 \cdot h^{18} - 218790 \cdot h^{16} + 411840 \cdot h^{14} - 420420 \cdot h^{12} + 252252 \cdot h^{10} - 90090 \cdot h^8 + 18480 \cdot h^6 - 1980 \cdot h^4 + 90 \cdot h^2 - 1$$

30 The normalized radius h_n is defined as :

$$h_n = \frac{\text{distance from optical axis}}{1/2 \text{ lens diameter of the aspheric surface}}$$

where $0 < h_n \leq 1$.

5 The surface shape components resulting from the Zernike polynomial Z9 contribute to spherical aberration of the third order. The portions resulting from the Zernike polynomial Z16 contribute to the correction of the fifth order spherical aberration. The contributions from the Zernike polynomial Z25 contribute to the correction of the seventh order
10 spherical aberration, and the portions from the Zernike polynomials Z36 contribute to the correction of the ninth order spherical aberration.

In tables 6Z, 7Z and 8Z all aspheric surfaces are characterized by the
15 Zernike coefficients with respect to the radius of the envelope sphere. Generally, the specific shapes and distribution of shapes in a dense sequence of aspheric surfaces will change if one aspheric surface is added or removed from that aspheric lens group since the specific contributions to a complex wavefront deformation must be distributed
20 anew. In spite of this, however, it has been found that some basic forms of asphericity appears to be beneficial even if the spatial density of aspherics is slightly changed in an aspheric lens group. In the following, these basic forms of asphericity are described in terms of selected ratios between selected Zernike coefficients for a lens group having a high
25 spatial density of aspheric surfaces.

Firstly, the object-side of the projection objective is considered. In an object-side aspheric lens group ALGO formed by lenses immediately downstream of the object plane and having at least three immediately
30 consecutive aspheric lens surfaces it is preferred that the first surface of

that aspheric lens group (i.e. the aspheric lens surface closest to the object plane) observes at least one of the following conditions:

$$-14 \geq K9/K16 \geq -25$$

5

$$+ 2 \leq K_{16}/K_{25} \leq 8.$$

For a second aspheric surface following the first aspheric surface of the object-side aspheric lens group at least one of the following conditions preferably holds:

10

$$-3,5 \geq K9/K16 \geq -7,5$$

+ 7 ≤ K16/K25 ≤ +25.

If the object-side aspheric lens group includes at least four immediately

15 consecutive aspheric lens surfaces, at least one of the two following conditions holds for a fourth aspheric lens surface following the first, second and third aspheric lens surface:

$$3 \leq K9/K16 \leq 5$$

20 $5 \leq K16/K25 \leq 15$.

In an object-side aspheric lens group having three, four, five or six immediately consecutive aspheric lens surfaces, the surface curvature at the vertex is preferably oriented such that the local radius of curvature

25 has its center on the image-side for all the aspheric lens surfaces. Alternatively, or in addition, the center of curvature of the envelope sphere is preferably on the image-side for all the aspheric lens surfaces of the object-side aspheric lens group.

30 If one or more or all of these conditions are observed for the object-side aspheric lens group, object-side telecentricity can be obtained at a very low level of distortion. The preferred conditions for the object-side

aspheric lens group are particularly useful for projection objectives having an object side numerical aperture $NA_O > 0,4$.

It has been found that a change of the sense of curvature of aspheric

5 lens surfaces will preferably occur as the axial position of the aspheric surfaces increases from the object plane. Whereas the lenses closest to the object plane preferably have a curvature radius center on the image-side, a second lens group G2 may be defined as the lens group starting with the first lens surface having the center of curvature on the object-

10 side. Preferably, the center of curvature of the first aspheric surface of the second group G2 and/or the second aspheric lens surface of that group lies on the object-side. Further, the shape of the first asphere of the second group preferably obeys the following condition:

15 $9 \leq K9/K16 \leq 20$.

Note that the second lens group G2 is formed by a single positive meniscus lens having an image-side convex surface in the embodiments of Figs 6 to 8. The second lens group may have more than one lens, e.g.

20 two lenses.

A third lens group G3 is preferably formed by a generally biconvex lens. Preferably, a first aspheric surface in the third lens group obeys at least one of the following conditions:

25

$$-20 \geq K9/K6 \geq -25$$

$$-2,5 \geq K16/K25 \geq -3,5$$

A second aspheric lens surface, normally formed by the exit surface of a

30 biconvex, biaspherical lens, preferably observes at least one of the following conditions:

$$+5,0 \leq K9/K16 \leq +8,0$$
$$+4 \leq K16/K25 \leq +7.$$

5 In a fifth lens group G5, which is arranged immediatley upstream of the first intermediate image in the embodiments of Figs 6 to 8, a first aspheric lens surface has at least one of the center of curvature at the vertex and the center of curvature of the envelope sphere on the image side and at least one of the following conditions holds:

10 $2,5 \leq K9/K16 \leq 3$
 $-4 \geq K16/K25 \geq -7.$

15 A penultimate aspheric lens surface in G5 preferably has the centers of curvatures mentioned above on the image side and at least one of the following conditions holds:

$$3 \leq K9/K16 \leq 5$$
$$6 \leq K16/K25 \leq 9.$$

20 For a last aspheric surface of the fifth lens group (positioned immediately upstream of the first intermediate image) the center of curvature of the envelope sphere is preferably on the image side and at least one of the following conditions holds:

25 $12 \leq K9/K16 \leq 18;$
 $4 \leq K16/K25 \leq 7$
 $6 \leq K25/K36 \leq 10.$

30 For the eighth lens group G8 arranged for receiving the radiation exiting the catadioptric second objective part COP2 it has been found that it is beneficial if an aspheric lens surface of that lens group observes at least one of the following conditions:

$$2,5 \leq K9/K16 \leq 4;$$

$$2,5 \leq K16/K25 \leq 4,0$$

$$3,0 \leq K25/K36 \leq 5.$$

5

In the embodiments of Figs 6 to 8 a ninth lens group G9 includes negative lenses and is designed to form a waist, i.e. a constriction of the beam diameter, whereby a contribution to Petzval sum correction is obtained in addition to correcting effects on other aberrations.

10 Preferably, a first aspheric lens surface of the ninth group G9 obeys at least one of the following conditions:

$$3 \leq K9/K16 \leq 5$$

$$3 \leq K16/K25 \leq 5.$$

15

If the ninth lens group G9 includes at least three and at most five consecutive aspheric lens surfaces the first aspheric lens surface of that group (in beam propagation direction) preferably obeys at least one of the following conditions:

20

$$-3 \geq K9/K25 \geq -5$$

$$+5 \leq K16/K25 \leq +7.$$

A second aspheric lens surface of that lens group preferably obeys at

25 least one of the following conditions:

$$0,3 \leq K9/K16 \leq 0,5$$

$$3,0 \leq K16/K25 \leq 5,0$$

30 A third aspheric lens surface of that lens group preferably obeys at least one of the following conditions:

$$3 \leq K9/K16 \leq 5$$

$$-25 \geq K16/K25 \geq -40.$$

5 A fourth aspheric lens surface of the ninth group preferably obeys at least one of the following conditions:

$$+5 \leq K9/K16 \leq +7$$

$$-3 \leq K16/K25 \leq -5.$$

10 A fifth aspheric lens surface of that ninth lens group preferably obeys at least one of the following conditions:

$$2,0 \leq K9/K16 \leq 3$$

$$10,0 \leq K16/K25 \leq 15,0$$

15

A tenth lens group G10 immediately upstream of the last optical element LOE is primarily designed to provide the high image-side numerical aperture. To this end, this lens group is primarily or exclusively composed of positive lenses. For a first aspheric lens surface on a

20 positive lens of this lens group at least one of the following conditions preferably holds:

$$500 \leq K9/K16 \leq 700$$

$$0,2 \leq K16/K25 \leq 0,3.$$

25

For a second aspheric lens surface following thereon, at least one of the following conditions preferably holds:

$$-7,0 \geq K9/K16 \geq -10,0$$

30 $1,3 \leq K16/K25 \leq 1,8.$

For an aspheric lens surface in the region of maximum beam diameter, preferably formed on a lens having low refractive power, at least one of the following conditions preferably holds:

5

$$6 \leq K9/K16 \leq 9$$

$$12 \leq K16/K25 \leq 17.$$

As noted above, it may be beneficial to have an aspheric lens group including at least three and at most five consecutive aspheric lens 10 surfaces immediately upstream of the last optical element in the region of the convergent beam. For a first aspheric lens of that group at least one of the following conditions preferably holds:

15

$$7,0 \leq K9/K16 \leq 12$$

$$-2,5 \geq K16/K25 \geq 5,0.$$

The aspheric lens surfaces close to the image plane are particularly important for correction and very high image-side numerical apertures. Depending on the actual number of aspherics in that region, there may 20 be a third aspheric lens surface of lens group immediately upstream of the last optical element (in beam propagation direction) which may be the penultimate aspheric lens group of that lens group. Preferably, at least one of the following conditions hold for that aspheric surface:

25

$$3 \leq K9/K16 \leq 5$$

$$10 \leq K16/K25 \leq 15.$$

A last aspheric surface of that lens group may or may not be the last aspheric surface of the projection objective before the image surface 30 depending on whether or not the last optical element LOE has an aspheric lens surface. For this last aspheric lens surface, at least one of the following conditions preferably holds:

$$+25 \leq K9/K16 \leq 40$$

$$-2 \geq K16/K25 \geq -4.$$

5 A last aspheric lens surface of the projection objective, which may be the last aspheric lens surface of a lens group immediately upstream of the last optical element or an aspheric lens surface of the last optical element preferably obeys at least one of the following conditions:

10 · $-1,8 \leq K9/K16 \leq 2,5$
 · $+1,3 \leq K16/K25 \leq 1,7$
 · $+2,5 \leq K25/K36 \leq 4,0$
 · $+3,5 \leq K36/K49 \leq 5,0$
 · $+4,5 \leq K49/K64 \leq 7,0.$

15 The above mentioned conditions in terms of Zernike coefficients have been derived from embodiments of catadioptric two-mirror in-line projection objectives having two intermediate images, as exemplified by Figs. 6 to 8 and other figures. It is contemplated that the conditions
20 observed for aspheric lens surfaces in the middle region of the projection objectives (e.g. within lens groups G4 to G8 or G9) may be specific for that type of projection objectives. However, it is also contemplated that the conditions derived for the aspheric lens surfaces close to the object surface (e.g. within the object-side aspheric lens group ALGO) and close
25 to the image plane (e.g. within the lens group immediately upstream of the last optical element and/or within the image-side aspheric lens group ALGI) are representative of projection objectives irrespective of the specific construction (refractive or catadioptric, with or without intermediate image, one or more concave mirrors etc.). Particularly, the
30 conditions for the image-side end region are considered to be applicable if a projection objective is used at high image-side numerical aperture $NA \geq 1,3$ or even $NA \geq 1,4$ in an optical limit range where the aperture

$\sin \alpha$ (angle α equals half the opening angle of a beam bundle within the last optical element) within the last optical element LOE corresponding to the ratio NA / n_{LOE} between the image-side numerical aperture and the refractive index n_{LOE} of the last optical element obeys the condition

5

$$\sin \alpha \geq 0,8$$

or even $\sin \alpha \geq 0,9$.

10 Consequently, the conditions are also considered to be beneficial independent of whether or not a high index material having refractive index $n \geq 1,6$ is used in any part of the projection objective, particularly on the image-side end thereof.

15 Therefore, the principles derived specifically for the object-side entry region and the image-side exit region of the very high NA projection objectives are considered to be universally applicable for projection objectives having comparable performance parameters with regard to object-side numerical aperture, magnification ratio, image-side numerical
20 aperture, object- and image-field size etc.

All exemplary embodiments discussed above are catadioptric projection objectives with exactly two concave mirrors and exactly two intermediate images, where all optical elements are aligned along one straight,

25 unfolded optical axis. The uniform basic type of projection objective chosen to explain preferred variants of the invention is intended to help illustrate some basic variants and technical effects and advantages related to different variants of the invention. However, the demonstrated use of lenses or lens elements made of high refractive index material
30 (e.g. $n \geq 1.6$ or even $n \geq 1.8$) in projection objectives particularly for operating wavelength in the deep ultraviolet range (DUV) is not restricted to this type of projection objectives. The invention can also be incorporated

into purely refractive projection objectives. In those types, the last optical element closest to the image plane is often a plano-convex lens which can be designed, for example, according to the rules laid out above for the last optical elements LOE in each of the first to fifth embodiment.

5 Examples are given e.g. in applicants US applications having serial numbers 10/931,051 (see also WO 03/075049 A), 10/931,062 (see also US 2004/0004757 A1), 10/379,809 (see US 2003/01744408) or in WO 03/077036 A. The disclosure of these documents is incorporated herein by reference.

10

Likewise, the invention can be implemented into catadioptric projection objectives having only one concave mirror, or catadioptric projection objectives having two concave mirrors in a arrangement different from that shown in the figures, or in embodiments having more than two

15 concave mirrors. Also, use of the invention can be made independent of whether or not folding mirrors are present in the optical design. Examples of catadioptric systems are given e.g. in applicants US applications having serial numbers 60/511,673, 10/743,623, 60/530,622, 60/560,267 or in US 2002/0012100 A1. The disclosure of these
20 documents is incorporated herein by reference. Other examples are shown in US 2003/0011755 A1 and related applications.

Likewise, the invention can be implemented into projection objectives without intermediate image, or with any suitable number of intermediate

25 images depending on demand.

Table 1Embodiment 1: NA = 1.45, β = -0.25, λ = 193.4 nm

SURF	RADIUS	THICKNESS	MATERIAL	INDEX	SEMDIAM.
0	0.000000	37.647680			62.000
1	200.438805	20.912608	SIO2HL	1.56018811	83.110
2	747.538013	7.881173			83.845
3	317.250503	20.945704	SIO2HL	1.56018811	86.831
4	22587.222465	11.951766			86.988
5	-354.957551	49.505975	SIO2HL	1.56018811	87.016
6	-278.404969	31.885410			92.050
7	133.981210	32.856595	SIO2HL	1.56018811	92.150
8	186.155059	11.833855			85.480
9	260.034334	38.111988	SIO2HL	1.56018811	85.440
10	-248.127931	0.945803			84.087
11	97.319012	29.863172	SIO2HL	1.56018811	63.308
12	247.011352	15.182258			54.518
13	0.000000	13.667911			46.858
14	-118.535589	9.039902	SIO2HL	1.56018811	47.472
15	-136.528381	10.289540			49.929
16	-117.640924	9.240335	SIO2HL	1.56018811	50.901
17	-267.170322	7.604882			57.478
18	-147.424814	27.656175	SIO2HL	1.56018811	58.338
19	-83.904407	29.670597			63.295
20	-79.022234	16.329258	SIO2HL	1.56018811	66.670
21	-99.429984	38.001255			76.192
22	-111.093244	49.234984	SIO2HL	1.56018811	86.007
23	-144.921986	0.952550			106.817
24	-6366.151454	44.409555	SIO2HL	1.56018811	119.243
25	-217.880653	270.750636			120.802
26	-219.739583	-239.183412		REFL	145.235
27	184.636114	269.507816		REFL	128.436
28	197.874974	37.626342	SIO2HL	1.56018811	86.078
29	524.125561	15.614096			81.640
30	-406.239674	8.985971	SIO2HL	1.56018811	81.383
31	106.800601	32.709694			77.510
32	-1162.346319	30.365146	SIO2HL	1.56018811	78.287
33	-161.881438	8.348534			81.054
34	-166.445156	11.418724	SIO2HL	1.56018811	81.127
35	-1076.211334	42.927908			95.134

36	-546.503260	41.443273	SIO2HL	1.56018811	113.022
37	-173.835591	0.952741			119.110
38	-372.875307	32.537548	SIO2HL	1.56018811	128.490
39	-210.380863	1.042699			131.802
40	303.213120	50.564746	SIO2HL	1.56018811	145.286
41	5346.623071	0.921057			144.413
42	262.055999	33.924688	SIO2HL	1.56018811	133.743
43	733.813747	0.928913			130.461
44	163.353186	39.409378	SIO2HL	1.56018811	116.482
45	349.938998	0.920003			111.971
46	279.917107	28.062402	SIO2HL	1.56018811	109.138
47	11299.235097	0.896338			104.077
48	88.608734	39.730068	SIO2HL	1.56018811	73.896
49	114.264419	0.751321			56.000
50	65.720894	25.021454	SAPHIR	1.92674849	49.523
51	131.441788	25.021469	SAPHIR	1.92674849	39.659
52	0.000000	1.000000	HINDEX	1.55600000	18.066
53	0.000000	0.000000	AIR	0.00000000	15.503

Table 1A
ASPHERIC CONSTANTS

SRF	1	6	8	12	16
K	0	0	0	0	0
C1	-2.263569e-08	5.432610e-08	-7.143508e-09	2.619298e-07	-3.184960e-07
C2	-9.879901e-13	-7.797101e-12	1.564097e-11	-3.814641e-11	-3.142211e-11
C3	3.070713e-17	8.455873e-16	-1.599946e-15	1.148617e-14	-1.728296e-15
C4	-6.018627e-21	-6.875038e-20	3.060476e-19	-4.506119e-18	-1.249207e-18
C5	4.073174e-26	3.863486e-24	-2.788321e-23	-5.794434e-23	-9.678014e-24
C6	1.391778e-29	-1.112310e-28	1.126553e-27	4.244063e-26	-4.921692e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	22	26	27	28	31
K	0	0	0	0	0
C1	2.863527e-08	8.694636e-09	-6.654566e-09	5.614883e-08	-1.288689e-07
C2	1.884154e-12	1.385871e-13	-1.686449e-13	1.450774e-12	-4.820574e-12
C3	1.636375e-17	1.727286e-18	-2.470942e-18	1.892047e-16	5.082977e-16
C4	1.888300e-20	4.461465e-23	-2.362157e-22	6.954696e-21	-1.375138e-19
C5	-2.021635e-24	-7.172318e-28	7.757389e-27	-1.108417e-24	1.555422e-23
C6	1.591959e-28	3.081240e-32	-3.330142e-31	2.459404e-28	-2.481857e-28
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	34	36	41	47	49
K	0	0	0	0	0
C1	-1.177998e-07	-2.187776e-08	-1.577571e-08	-8.244653e-09	2.024084e-07
C2	-5.683441e-12	-8.068584e-14	3.706857e-13	4.957466e-12	1.422789e-11
C3	-5.647064e-16	8.600815e-17	-1.492063e-17	-2.442972e-16	3.923209e-15
C4	-7.031797e-21	-2.071494e-20	-9.742126e-22	6.741381e-21	4.845684e-19
C5	-1.902336e-24	1.290940e-24	6.498365e-26	2.034640e-25	-2.134986e-22
C6	2.891112e-29	-3.884318e-29	-9.630077e-31	-2.570056e-29	5.591977e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	9.579172e-34	0.000000e+00

Table 2Embodiment 2 (b037b): NA = 1.35, β = -0.25, λ = 193.4 nm

SURF	RADIUS	THICKNESS	MATERIAL	INDEX	SEMIDIAM.
0	0.000000	37.647680			62.000
1	526.196808	49.977602	SIO2HL	1.56018811	75.944
2	-256.668548	1.120100			85.473
3	696.160336	28.649736	SIO2HL	1.56018811	90.668
4	-2056.955285	22.244610			92.750
5	-195.811665	49.974335	SIO2HL	1.56018811	92.870
6	-158.185918	9.821764			101.539
7	138.796255	49.218181	SIO2HL	1.56018811	90.394
8	301.060143	1.660319			80.597
9	161.646552	42.095627	SIO2HL	1.56018811	78.153
10	-406.812049	0.979493			70.852
11	100.020556	24.469422	SIO2HL	1.56018811	52.354
12	102.330592	10.088496			38.573
13	0.000000	10.406389			37.226
14	-157.109979	8.950512	SIO2HL	1.56018811	38.841
15	618.822068	8.847956			46.776
16	-561.300665	33.147649	SIO2HL	1.56018811	51.388
17	-73.150544	9.448760			56.377
18	-69.300574	8.926672	SIO2HL	1.56018811	57.781
19	-86.551998	8.003693			64.608
20	-78.306541	10.360105	SIO2HL	1.56018811	66.592
21	-117.142798	2.915635			75.827
22	-356.673528	46.693825	SIO2HL	1.56018811	86.465
23	-108.386760	266.538313			90.245
24	-177.092218	-236.552196		REFL	129.567
25	200.462621	288.213928		REFL	136.687
26	604.677438	50.022575	SIO2HL	1.56018811	82.440
27	125.234518	13.901039			73.274
28	257.421526	34.367199	SIO2HL	1.56018811	73.449
29	111.034905	29.307766			73.890
30	-848.480773	29.119950	SIO2HL	1.56018811	74.404
31	-194.073508	7.840952			80.032
32	-225.307336	46.053997	SIO2HL	1.56018811	81.668
33	-535.709449	0.941640			105.651

34	-1622.810467	46.410355	SIO2HL	1.56018811	108.373
35	-173.207717	0.932943			113.398
36	-236.921577	22.327373	SIO2HL	1.56018811	116.764
37	-261.220038	0.938270			124.709
38	364.988031	40.936258	SIO2HL	1.56018811	142.520
39	11406.698081	0.943482			142.679
40	379.203162	36.840265	SIO2HL	1.56018811	142.867
41	-33782.420006	0.921857			141.929
42	245.879991	49.886843	SIO2HL	1.56018811	134.831
43	-10061.581161	0.883850			132.020
44	145.995266	39.892414	SIO2HL	1.56018811	105.854
45	375.256079	0.817132			99.565
46	86.107554	37.429431	SIO2HL	1.56018811	73.276
47	215.234027	0.667291			63.094
48	52.718236	26.546970	SIO2HL	1.56018811	42.800
49	0.000000	16.594510	SAPHIR	1.92674849	42.800
50	0.000000	0.999826	H2O	1.43612686	42.800
51	0.000000	0.000000	AIR	0.00000000	15.501

Table 2A
ASPHERIC CONSTANTS

SRF	1	6	9	12	14
K	0	0	0	0	0
C1	-8.448852e-08	-4.108258e-09	-6.153759e-08	4.456016e-07	-6.305745e-07
C2	-4.761055e-12	-9.598657e-12	-1.480269e-11	1.857407e-11	-7.903687e-11
C3	-1.420861e-16	1.072661e-15	1.473191e-15	1.064538e-14	-2.534563e-14
C4	-8.023974e-20	-6.889975e-20	-3.255374e-19	-5.079476e-18	-3.735078e-18
C5	1.173437e-23	2.314066e-24	3.131675e-23	1.056992e-22	1.905659e-22
C6	-1.454073e-27	-3.793935e-29	-6.955428e-28	7.981996e-26	-3.500146e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	20	24	25	26	29
K	0	0	0	0	0
C1	1.209336e-07	1.259532e-08	-4.077497e-09	1.111414e-07	-8.942189e-08
C2	1.869926e-11	3.424345e-13	-8.690596e-14	3.172584e-13	-1.116520e-13
C3	1.314270e-15	6.952906e-18	-1.505812e-18	3.429058e-19	4.168290e-16
C4	3.650689e-19	3.744203e-22	-8.583957e-23	-1.068048e-20	-2.231424e-19
C5	-5.603440e-23	-1.203108e-26	2.784182e-27	1.935865e-24	2.267328e-23
C6	9.844086e-27	6.714766e-31	-1.066606e-31	-5.318242e-29	-1.588914e-27
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	32	34	39	45	47
K	0	0	0	0	0
C1	-9.549663e-08	-5.673614e-09	-1.220571e-08	-2.613273e-08	1.649072e-07
C2	-3.034519e-12	-5.774683e-14	4.574492e-13	4.882999e-12	-4.982295e-13
C3	1.985443e-16	-1.715933e-16	-3.026161e-17	-2.171852e-16	-2.462341e-16
C4	-1.403621e-20	5.949307e-21	8.480395e-22	8.220913e-21	6.329880e-19
C5	2.496197e-24	1.220843e-25	-5.629908e-27	2.183741e-25	-1.498580e-22
C6	-1.598958e-28	-2.178077e-29	-3.377722e-32	-2.816869e-29	1.552461e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	1.520501e-33	0.000000e+00

Table 3Embodiment 3 (b037a): NA = 1.45, β = -0.25, λ = 193.4 nm

SURF	RADIUS	THICKNESS	MATERIAL	INDEX	SEMITDIAM.
0	0.000000	37.647680			62.000
1	178.098560	47.089109	SIO2HL	1.56018811	83.684
2	508.791874	0.982161			86.920
3	260.152118	29.610169	SIO2HL	1.56018811	89.203
4	-897.680969	14.988854			89.348
5	-224.555868	50.010854	SIO2HL	1.56018811	89.318
6	-167.290149	6.943751			94.603
7	185.350898	29.083481	SIO2HL	1.56018811	84.200
8	161.696842	4.567325			74.817
9	156.295097	29.687097	SIO2HL	1.56018811	74.801
10	-1628.579737	27.610587			72.999
11	116.709207	25.652869	SIO2HL	1.56018811	57.349
12	3359.816893	2.336800			52.702
13	0.000000	42.058143			50.890
14	-114.711496	34.899486	SIO2HL	1.56018811	53.065
15	-73.282662	4.817213			60.856
16	-72.166685	17.818288	SIO2HL	1.56018811	60.190
17	-80.823907	4.905081			66.269
18	-78.170209	34.642475	SIO2HL	1.56018811	65.802
19	-161.353349	3.907912			83.613
20	-250.115507	50.004289	SIO2HL	1.56018811	87.033
21	-130.504962	244.427626			94.956
22	-180.721067	-214.432541		REFL	135.011
23	179.125663	274.568868		REFL	126.490
24	337.886373	47.239794	SIO2HL	1.56018811	107.066
25	-899.516467	5.847365			104.221
26	-2346.009271	43.828445	SIO2HL	1.56018811	101.016
27	101.771490	35.484160			86.055
28	-4439.596410	23.703533	SIO2HL	1.56018811	86.263
29	-254.324560	5.801976			87.609
30	-445.540133	48.164461	SIO2HL	1.56018811	87.772
31	-735.213902	16.951226			100.097
32	-650.817086	49.961292	SIO2HL	1.56018811	102.416
33	-281.005458	31.479288			116.698

34	-649.019441	49.768062	SIO2HL	1.56018811	130.316
35	-215.856617	0.928162			134.641
36	312.849138	39.828764	SIO2HL	1.56018811	135.256
37	-1022.199791	0.857904			133.831
38	278.748013	42.635737	SIO2HL	1.56018811	128.369
39	-3295.326556	0.914469			126.650
40	128.656616	61.387113	SIO2HL	1.56018811	106.520
41	-2188.188515	0.730038			100.722
42	90.065507	18.596750	SIO2HL	1.56018811	69.706
43	93.775489	1.000000			60.097
44	73.203900	33.227474	SAPHIR	1.92674849	55.900
45	0.000000	11.657723	SIO2HL	1.56018811	55.900
46	0.000000	0.999913	HIINDEX	1.55600000	55.900
47	0.000000	0.000000	AIR	0.00000000	15.520

Table 3A**ASPHERIC CONSTANTS**

SRF	1	6	8	12	14
K	0	0	0	0	0
C1	-3.797021e-08	4.091151e-08	9.284044e-09	1.793476e-07	-3.526789e-07
C2	-1.858357e-12	-7.880362e-12	2.927990e-11	-4.710051e-11	-5.029864e-11
C3	6.026920e-17	9.074630e-16	-2.187906e-15	2.197728e-15	-6.353989e-15
C4	-3.792813e-20	-7.153651e-20	3.131133e-19	-3.553387e-18	-2.243484e-18
C5	3.121506e-24	2.884237e-24	-3.422295e-23	-7.638265e-23	1.422334e-23
C6	-1.940311e-28	-4.358943e-29	2.472280e-27	2.576563e-26	-7.652798e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	18	22	23	24	27
K	0	0	0	0	0
C1	4.805447e-08	1.366493e-08	-7.247654e-09	2.039086e-09	-2.335210e-07
C2	6.053101e-12	3.157722e-13	-1.844324e-13	4.079171e-12	-3.581428e-12
C3	1.864225e-16	4.418704e-18	-3.130608e-18	3.415807e-19	8.204976e-16
C4	1.774391e-19	3.842541e-22	-2.876782e-22	-3.143532e-21	-1.472132e-19
C5	-1.538124e-23	-1.422352e-26	1.047999e-26	-6.009771e-26	1.193755e-23
C6	1.486597e-27	5.625242e-31	-4.798652e-31	5.373759e-30	-5.012293e-28
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	30	32	37	41	43
K	0	0	0	0	0
C1	-9.015949e-08	-4.710517e-08	2.981775e-08	7.825942e-08	-1.254855e-07
C2	-5.963683e-12	1.502154e-12	-1.562632e-15	-5.678508e-12	4.044789e-11
C3	-2.709599e-17	-1.008729e-16	-1.924785e-17	9.897699e-16	5.935178e-15
C4	1.782520e-20	-2.037099e-20	1.470777e-21	-1.257950e-19	-7.518165e-19
C5	-1.313151e-25	1.244695e-24	-9.287054e-26	1.131690e-23	5.626054e-23
C6	1.114296e-28	-7.926554e-29	2.454712e-30	-6.106697e-28	5.101190e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	1.494562e-32	0.000000e+00

Table 4Embodiment 4: NA = 1.35, β = -0.25, λ = 193.4 nm

SURF	RADIUS	THICKNESS	MATERIAL	INDEX	SEMIDIAM.
0	0.000000	37.647680			62.000
1	213.097095	21.139875	SIO2HL	1.56018811	81.073
2	980.962863	0.933467			81.638
3	312.309311	19.869666	SIO2HL	1.56018811	82.923
4	7050.227976	14.977212			82.853
5	-284.845054	46.899913	SIO2HL	1.56018811	82.842
6	-316.674517	31.820687			87.867
7	127.504953	32.199127	SIO2HL	1.56018811	90.842
8	177.687028	14.069304			84.748
9	233.816949	49.949045	SIO2HL	1.56018811	84.566
10	-272.601570	1.802731			81.010
11	92.974202	24.948435	SIO2HL	1.56018811	61.866
12	228.036841	31.795297			55.983
13	-128.436888	15.028089	SIO2HL	1.56018811	45.986
14	-208.039449	19.686225			50.292
15	-85.822730	9.039605	SIO2HL	1.56018811	51.590
16	-124.923386	5.248146			59.096
17	-134.255203	24.981296	SIO2HL	1.56018811	61.621
18	-86.028170	70.079618			66.114
19	-91.784845	49.926992	SIO2HL	1.56018811	78.125
20	-130.258172	3.354815			102.297
21	-819.889396	43.461173	SIO2HL	1.56018811	114.993
22	-193.549016	277.291798			117.690
23	-220.432400	-231.344649		REFL	147.536
24	175.171589	261.356424		REFL	120.087
25	222.618410	49.895981	SIO2HL	1.56018811	93.866
26	227.634130	10.722465			85.687
27	469.132386	43.799915	SIO2HL	1.56018811	85.491
28	112.693662	31.313114			76.622
29	12293.399547	31.702057	SIO2HL	1.56018811	77.313
30	-155.449641	4.962336			79.575
31	-219.506451	26.268152	SIO2HL	1.56018811	79.827
32	-1377.822971	32.354789			93.063
33	-519.892544	47.183977	SIO2HL	1.56018811	101.635

34	-163.140684	1.841108			110.786
35	-340.920966	26.977392	SIO2HL	1.56018811	116.967
36	-214.582539	2.006234			120.143
37	271.181444	53.143321	SIO2HL	1.56018811	127.047
38	-1118.441818	19.790952			125.887
39	0.000000	-14.609943			112.489
40	174.102740	52.205661	SIO2HL	1.56018811	107.954
41	-663.589997	3.836965			104.404
42	84.561977	46.625084	SIO2HL	1.56018811	71.481
43	95.046969	0.694913			51.033
44	64.492898	46.885676	SAPIR	1.92674849	46.520
45	0.000000	1.000000	H2O	1.43612686	18.265
46	0.000000	0.000000	AIR	0.00000000	15.515

Table 4A

ASPHERIC CONSTANTS

SRF	1	6	8	12	15
K	0	0	0	0	0
C1	-7.766221e-09	3.921777e-08	-1.973978e-08	2.262385e-07	-2.849645e-07
C2	-1.414298e-12	-7.469962e-12	1.686856e-11	-3.111178e-11	-3.795087e-11
C3	2.026799e-16	9.877277e-16	-1.521195e-15	8.999889e-15	-4.195519e-15
C4	-9.311177e-21	-6.240165e-20	2.838141e-19	-4.631502e-18	-2.684695e-18
C5	8.983777e-26	3.683666e-24	-2.893390e-23	7.225241e-23	-2.249016e-23
C6	-5.139250e-30	-1.606542e-28	1.372152e-27	5.035383e-26	-5.606361e-26
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	19	23	24	25	28
K	0	0	0	0	0
C1	2.306275e-08	9.197905e-09	-7.280789e-09	8.044076e-08	-1.035389e-08
C2	1.672430e-12	1.297990e-13	-2.062090e-13	6.845761e-13	5.752946e-14
C3	-3.451288e-18	1.447412e-18	-3.885785e-18	8.440855e-17	3.412577e-16
C4	3.656429e-20	4.002605e-23	-3.101616e-22	-8.233892e-21	-1.247784e-19
C5	-5.091821e-24	-7.044663e-28	1.113163e-26	1.115110e-24	5.556509e-24
C6	5.148418e-28	3.011922e-32	-6.186058e-31	-3.079026e-29	1.295943e-27
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	31	33	38	41	44
K	0	0	0	0	0
C1	-1.291718e-07	-4.530057e-08	-1.801990e-08	-2.682021e-08	-1.900216e-07
C2	-4.385607e-12	-2.081953e-13	6.277450e-13	7.361672e-12	-4.832504e-11
C3	-2.255698e-16	1.680387e-16	-5.256278e-17	-3.951877e-16	-1.233010e-14
C4	-2.117620e-21	-4.155797e-20	-4.688822e-21	1.434967e-20	7.440284e-19
C5	-1.322919e-24	3.040355e-24	4.497908e-25	-3.980440e-26	1.430823e-22
C6	1.074049e-28	-1.238033e-28	-9.348185e-30	-2.642973e-29	-3.924075e-25
C7	0.000000e+00	0.000000e+00	0.000000e+00	1.163864e-33	0.0000

Table 5Embodiment 5: NA = 1.6, β = -0.25, λ = 193.4 nm

SURF	RADIUS	THICKNESS	MATERIAL	INDEX	SEMDIAM.
0	0.000000	37.663108			62.000
1	192.084227	26.622297	SIO2V	1.56078570	87.833
2	1075.649716	0.946456			88.233
3	491.402040	19.101530	SIO2V	1.56078570	88.867
4	-934.209447	36.905290			88.935
5	125.340633	9.623977	SIO2V	1.56078570	90.013
6	122.019859	23.963817			87.312
7	252.185057	44.239148	SIO2V	1.56078570	87.669
8	-204.394078	0.923049			87.161
9	102.471834	52.852020	SIO2V	1.56078570	67.768
10	254.533994	9.305878			48.073
11	0.000000	52.418616			46.820
12	-75.641562	68.872834	SIO2V	1.56078570	58.068
13	-124.953275	39.621161			93.864
14	-835.558655	54.318921	SIO2V	1.56078570	126.993
15	-178.850083	0.948020			130.230
16	2111.392648	22.857019	SIO2V	1.56078570	132.098
17	-901.583067	358.679202			132.071
18	-225.015829	-231.613549		REFL	160.876
19	168.185189	261.594819		REFL	120.144
20	-736.571530	23.114077	SIO2V	1.56078570	81.485
21	132.965130	36.406211			86.933
22	-512.908458	28.535664	SIO2V	1.56078570	87.621
23	-185.099986	6.615931			92.898
24	-544.628556	33.807132	SIO2V	1.56078570	99.839
25	-547.431224	19.995820			114.885
26	-359.224408	99.479683	SIO2V	1.56078570	119.014
27	-168.873687	12.916761			143.505
28	313.449462	92.758623	SIO2V	1.56078570	165.026
29	983.057723	1.167054			158.153
30	227.152511	48.817493	SIO2V	1.56078570	148.584
31	684.382976	0.981700			144.866
32	144.775480	60.829967	SIO2V	1.56078570	121.541
33	1285.387522	0.899534			116.276

34	99.002284	39.642869	SIO2V	1.56078570	84.155
35	243.117451	0.805490			74.674
36	65.952055	54.681070	SAPHIR	1.92674849	54.379
37	0.000000	0.000000	AIR	0.00000000	15.530

Table 5A
ASPHERIC CONSTANTS

SRF	4	5	10	14	18
K	0	0	0	0	0
C1	4.332466e-08	5.983847e-08	4.678448e-07	-5.502311e-09	9.581997e-09
C2	-4.251613e-12	-1.394334e-11	1.214772e-11	6.759433e-14	1.191548e-13
C3	8.548420e-16	1.246293e-15	1.462858e-14	-2.777895e-18	5.628084e-19
C4	-7.822847e-20	-2.065935e-19	-5.084805e-18	1.850960e-22	7.255139e-23
C5	3.463295e-24	1.861321e-23	4.192361e-22	-7.883399e-27	-1.691943e-27
C6	-7.495559e-29	-7.372680e-28	1.456331e-26	1.533878e-31	3.619858e-32
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	19	20	21	24	26
K	0	0	0	0	0
C1	-5.661490e-09	8.762490e-08	-3.207763e-08	-6.520443e-08	4.364974e-09
C2	-1.921628e-13	-1.093121e-11	-5.311243e-12	4.777722e-13	-1.522836e-12
C3	-7.055884e-19	1.359734e-15	6.816058e-16	-7.895875e-17	-6.656442e-18
C4	-6.935220e-22	-2.479964e-19	-2.253013e-19	1.733738e-20	-2.640069e-21
C5	3.152816e-26	2.421781e-23	2.354847e-23	-2.097861e-24	2.889539e-25
C6	-1.191863e-30	-1.346005e-27	-1.003551e-27	1.235456e-28	-1.101803e-29
C7	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00	0.000000e+00

SRF	29	33	35
K	0	0	0
C1	8.788855e-09	3.258556e-08	1.084860e-07
C2	-6.462954e-13	1.588293e-12	6.094001e-12
C3	-1.551858e-17	-1.752790e-16	1.646644e-16
C4	1.099566e-21	1.227022e-20	-9.287322e-20
C5	-1.930245e-26	-5.173475e-25	1.657126e-23
C6	1.160550e-31	1.295964e-29	-1.278529e-27
C7	0.000000e+00	-1.104258e-34	0.000000e+00

Table 6

Shs2034

SURFACE	RADIUS	THICKNESS	MATERIAL	INDEX 193.304nm	1/2	DIAM
0	0.0000000000	13.434225652900		1.00000000	52.000	
1	204.3874298230AS	17.365428346000 SIO2		1.56028895	65.838	
2	1142.1626550800AS	16.068315513400		1.00000000	66.043	
3	86.0159109378AS	25.645556590600 SIO2		1.56028895	75.536	
4	137.3169382110AS	35.568722228500		1.00000000	72.244	
5	2336.6623042800AS	31.001793035800 SIO2		1.56028895	71.797	
6	-139.4399592830	0.700000001770		1.00000000	72.786	
7	380.7794975610AS	15.351197739400 SIO2		1.56028895	65.487	
8	-224.3812337980AS	31.039821568900		1.00000000	63.930	
9	0.0000000000	60.200321556900		1.00000000	53.223	
10	-64.2099274206	27.604283673900 SIO2		1.56028895	59.641	
11	-79.6540010816	0.700000000000		1.00000000	74.506	
12	273.1750003050AS	32.289852713200 SIO2		1.56028895	106.773	
13	-2069.8862901100	0.700100443811		1.00000000	107.271	
14	165.6617490420AS	76.997028967600 SIO2		1.56028895	110.845	
15	-897.7469015400AS	53.895298167500		1.00000000	99.388	
16	261.0741714970	256.541672929000		1.00000000	87.549	
17	-146.7196028870AS-256.541672929000			-1.00000000	96.805	
REFL						
18	261.0741714970AS	256.541672929000		1.00000000	201.836	
REFL						
19	0.0000000000	30.496109909800		1.00000000	121.258	
20	108.0456074120AS	39.156429063400 SIO2		1.56028895	87.427	
21	132.3053653420	31.766137286300		1.00000000	77.996	
22	801.6162930400AS	8.312069682500 SIO2		1.56028895	74.098	
23	165.0526781810	9.338882890150		1.00000000	68.743	
24	204.5021848420AS	7.50000000060 SIO2		1.56028895	68.005	
25	90.1620315715AS	51.282703485500		1.00000000	63.506	
26	-176.5279024460AS	9.804717509200 SIO2		1.56028895	66.348	
27	189.2637811660AS	36.506600017800		1.00000000	82.033	
28	-201.8303829090AS	16.951309066700 SIO2		1.56028895	86.005	
29	-294.2996128650	2.217117105890		1.00000000	100.199	
30	1265.9959137700AS	69.614142391400 SIO2		1.56028895	122.039	
31	-158.1782206310	0.933343606060		1.00000000	127.287	
32	1407.0565305900AS	71.176921112100 SIO2		1.56028895	159.879	
33	-286.7741415570	10.539079572600		1.00000000	162.460	
34	528.8765359890	20.852268104100 SIO2		1.56028895	160.082	
35	620.1839994330AS	0.724062897109		1.00000000	159.105	
36	190.2199493410	46.240223494100 SIO2		1.56028895	146.454	
37	324.9149551340AS	0.701214555902		1.00000000	142.621	
38	154.5074744160	52.370101208200 SIO2		1.56028895	123.749	
39	525.8220856250AS	0.700181398503		1.00000000	117.757	
40	105.0571199310AS	39.055206860100 SIO2		1.56028895	85.088	
41	251.0605459890AS	0.700000009697		1.00000000	77.136	
42	61.2471992195AS	8.767875977760 SIO2		1.56028895	55.044	
43	36.0000000000	0.200000000000 IMM		1.56100000	36.000	
44	35.3477405743	47.730836867600 SAPHIR		1.92803200	35.348	
45	0.0000000000	0.000000000000		1.00000000	13.000	

Table 6 A

ASPHERIC CONSTANTS

SURFACE NR. 1		SURFACE NR. 5	
K	0.000000000000	K	0.000000000000
C1	2.15559563865e-007	C1	-1.02837002998e-007
C2	3.47269567925e-011	C2	-9.89947180534e-011
C3	-1.32743925608e-014	C3	2.24018654893e-014
C4	2.13245136549e-018	C4	-2.57279667909e-018
C5	-1.04461360941e-022	C5	1.31518529616e-022
C6	-8.45930586562e-027	C6	-1.49133855112e-027
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 2		SURFACE NR. 7	
K	0.000000000000	K	0.000000000000
C1	2.42680157673e-007	C1	-9.01134401945e-008
C2	5.78637970516e-014	C2	3.01055087653e-011
C3	-4.66956436865e-015	C3	-3.82363758531e-015
C4	3.73035264802e-019	C4	8.33075663400e-019
C5	1.15267036277e-022	C5	-7.35510347731e-022
C6	-2.25371431397e-026	C6	1.02885094729e-025
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 3		SURFACE NR. 8	
K	0.000000000000	K	0.000000000000
C1	9.62983836062e-009	C1	2.28096057131e-007
C2	-1.15848618185e-011	C2	2.63297748454e-011
C3	1.45469569660e-015	C3	2.89958634508e-015
C4	-9.24677985263e-020	C4	2.69025329856e-019
C5	6.17618145883e-024	C5	-4.37286778691e-022
C6	-1.29171167523e-028	C6	7.36963882703e-026
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 4		SURFACE NR. 12	
K	0.000000000000	K	0.000000000000
C1	3.68219046737e-008	C1	-1.08578542065e-008
C2	2.99597572849e-011	C2	1.15897820514e-012
C3	-1.88053833273e-015	C3	1.61159703971e-017
C4	4.65784947865e-019	C4	-1.98581987305e-021
C5	-1.81718657348e-023	C5	4.59387968528e-026
C6	2.01146986754e-027	C6	-7.75179834831e-031
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000

SURFACE NR. 14

K	0.000000000000
C1	4.56717247971e-009
C2	6.05265329766e-013
C3	-1.57336406950e-017
C4	1.73349069478e-021
C5	-2.24443235811e-026
C6	-3.21226511551e-032
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 20

K	0.000000000000
C1	1.09063780649e-009
C2	2.41347526915e-013
C3	-3.49022317083e-017
C4	5.96622397636e-021
C5	-4.76391067699e-025
C6	3.36304260357e-029
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 15

K	0.000000000000
C1	1.24012917431e-007
C2	6.88679826614e-013
C3	1.79993705657e-017
C4	3.28162687874e-021
C5	-5.12141876726e-026
C6	1.82676171351e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 22

K	0.000000000000
C1	3.28730013300e-008
C2	2.67725791434e-012
C3	-8.77612115397e-016
C4	2.74025083311e-019
C5	-2.94821254019e-023
C6	1.38371215675e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 17

K	-0.141806648213
C1	1.42797597968e-008
C2	4.87650527548e-013
C3	2.67713889789e-018
C4	1.30093166713e-021
C5	-5.44526859997e-026
C6	2.45603797485e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 24

K	0.000000000000
C1	-7.45788707680e-008
C2	1.23793311020e-011
C3	-3.18968579478e-015
C4	-9.46422242864e-019
C5	2.12313752406e-022
C6	-1.22943475906e-026
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 18

K	-0.333522671830
C1	4.07717280407e-010
C2	4.97218066225e-015
C3	3.41161783470e-020
C4	7.60421041523e-025
C5	-6.13534482230e-030
C6	1.46422388270e-034
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 25

K	0.000000000000
C1	-2.93508405651e-009
C2	2.32860225180e-011
C3	-2.50652260330e-015
C4	-1.18381249114e-018
C5	1.40037428387e-022
C6	1.47882131747e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 26

K	0.000000000000
C1	-1.77688857374e-008
C2	-1.04099845293e-011
C3	-3.62402222822e-015
C4	5.23096050239e-019
C5	-5.56344386153e-023
C6	2.85184791444e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 32

K	0.000000000000
C1	-4.79983324244e-010
C2	-7.59672446738e-015
C3	1.13909585954e-019
C4	5.21104458389e-025
C5	1.69574498336e-027
C6	-4.14079584136e-032
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 27

K	0.000000000000
C1	2.42141471393e-008
C2	-1.09079610419e-011
C3	-4.38567604241e-015
C4	1.09882688211e-018
C5	-1.03478683716e-022
C6	3.81545440937e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 35

K	0.000000000000
C1	-1.09859844654e-008
C2	6.92192966090e-014
C3	-7.90470393533e-018
C4	-2.80761708448e-022
C5	1.46654006207e-026
C6	-1.61624013736e-031
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 28

K	0.000000000000
C1	-1.85204408243e-008
C2	3.92673589370e-012
C3	2.05047525875e-016
C4	-2.78920677409e-021
C5	-3.39994106260e-026
C6	1.08861694678e-028
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 37

K	0.000000000000
C1	-2.96676883270e-009
C2	-2.06488328052e-013
C3	-1.43371546279e-018
C4	-6.78491894336e-023
C5	6.97408517528e-027
C6	4.92679247796e-032
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 30

K	0.000000000000
C1	-3.82792958476e-008
C2	4.03438821160e-013
C3	-1.64535675887e-017
C4	-3.01893664173e-022
C5	4.34266604202e-026
C6	-2.08739982859e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 39

K	0.000000000000
C1	7.60133220905e-009
C2	1.56591482650e-013
C3	1.01464432332e-016
C4	-6.41181749755e-021
C5	2.56797352661e-025
C6	-4.06394006222e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 40

K	0.000000000000
C1	6.00864999995e-008
C2	1.54951310671e-012
C3	2.95817046515e-016
C4	1.52932567259e-020
C5	-1.91359153221e-025
C6	4.03904851500e-028
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 41

K	0.000000000000
C1	1.28537465592e-007
C2	1.13373406274e-012
C3	4.58603338636e-016
C4	-2.43895218759e-020
C5	-1.87969207694e-024
C6	-1.33020757412e-028
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 42

K	0.000000000000
C1	-1.06506281524e-007
C2	-2.07189661732e-011
C3	-3.34536569101e-015
C4	-5.55548935549e-019
C5	1.27150562286e-022
C6	1.16078588552e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

Table 6Z
SHS 2034

Nr	Sf	Rv	REnv	2*Hmax	Def[mpj]	216	225	236	249	264	281
1:	1	204.39	149.48	128.99	906.0	607.50	-30.79	-8.18	0.00	-1.277	-0.0531
2:	2	-1142.16	-401.48	129.35	713.2	-473.48	67.25	7.45	2.08	1.245	0.1472
3:	3	86.02	86.68	146.09	79.6	-60.63	17.67	15.71	1.24	0.404	0.0416
4:	4	-137.32	-115.59	139.10	1314.6	-832.51	-203.65	-23.90	-4.75	-0.204	-0.0349
5:	5	2336.66	-454.98	137.35	1759.2	-1184.23	-17.83	22.36	-8.33	1.273	-0.0226
6:	6	380.78	464.41	126.32	321.0	-184.43	-71.11	-55.43	5.17	3.059	0.4822
7:	8	224.38	538.02	123.36	1479.9	-976.91	-99.47	-6.46	-4.14	-1.784	-0.2476
8:	12	273.18	268.56	221.47	365.8	-229.33	86.38	-7.92	-1.05	0.047	-0.0094
9:	14	165.66	160.21	227.80	483.7	312.75	62.66	5.19	0.45	-0.236	-0.0153
10:	15	897.75	-586.24	203.91	3882.4	-2578.70	-108.64	-15.36	-1.35	-0.021	-0.0070
11:	17	-146.72	-155.15	193.61	511.7	337.75	34.57	3.18	0.34	0.027	0.0005
12:	18	-261.07	-273.22	403.67	1186.6	756.16	152.09	27.66	4.68	0.727	0.0978
13:	20	108.05	107.80	178.57	29.2	18.66	4.61	1.52	0.47	0.051	0.0073
14:	22	801.62	559.38	151.29	471.9	306.75	43.57	8.22	0.59	-0.067	0.0810
15:	24	204.50	255.08	137.49	829.7	-524.53	-128.81	-15.65	4.78	0.108	-0.1886
16:	25	-90.16	-89.72	127.07	103.4	-127.07	17.79	-2.69	-0.743	-0.0061	0.00015
17:	26	-176.53	-155.07	131.42	677.0	-433.47	-102.30	-4.60	0.62	-0.088	0.0233
18:	27	-189.26	-220.58	157.62	984.7	657.53	108.11	-30.63	-0.11	1.276	-0.3964
19:	28	-201.83	-212.14	167.14	523.2	312.67	124.00	12.06	1.75	0.330	0.0257
20:	30	1266.00	-7224.09	227.28	1480.8	-984.52	-7.01	-8.58	-0.84	-0.256	0.0000
21:	32	1407.06	1442.79	295.20	36.8	-23.42	11.31	3.38	0.00	-0.169	0.0000
22:	35	-620.18	-1014.16	304.16	2167.7	1425.44	173.11	12.99	-6.51	-0.262	0.1667
23:	37	-324.91	-352.45	282.80	774.1	522.77	46.40	-20.18	-5.86	-0.721	-0.0184
24:	39	-525.82	-406.99	240.20	1458.2	-910.92	-193.43	-42.92	0.20	-0.503	0.1538
25:	40	105.06	98.61	175.40	625.2	473.07	34.96	0.09	-4.33	-1.911	-0.5581
26:	41	-251.06	-176.51	163.03	1466.2	-984.32	-14.98	14.30	4.90	0.464	0.0222
27:	42	61.25	62.75	112.90	143.0	-127.78	49.34	35.43	11.79	2.671	0.4590

Table 7

Shs2035

SURFACE	RADIUS	THICKNESS	MATERIAL	INDEX 193.304nm	1/2 DIAM
0	0.0000000000	15.679282349200		1.00000000	52.000
1	188.9361455030AS	18.288674598600 SIO2		1.56028895	68.284
2	694.1043431650AS	13.221429473000		1.00000000	68.292
3	84.8053215142AS	26.533452202300 SIO2		1.56028895	75.689
4	139.9217727560AS	35.813107735000		1.00000000	71.829
5	991.1217961470AS	26.635290884600 SIO2		1.56028895	71.359
6	-152.4471481430	0.705435225252		1.00000000	71.866
7	561.4522817590AS	15.771790808700 SIO2		1.56028895	66.252
8	-188.7715763730AS	31.039821568900		1.00000000	64.663
9	0.0000000000	60.200321556900		1.00000000	53.209
10	-63.2575986324	27.604744379400 SIO2		1.56028895	59.416
11	-80.7157309618	0.700000551729		1.00000000	75.455
12	296.4896501680AS	37.879478386600 SIO2		1.56028895	111.891
13	-763.9145212360	0.700037253092		1.00000000	112.624
14	170.2692851210AS	80.042091181800 SIO2		1.56028895	116.621
15	-952.4975107830AS	66.049513376500		1.00000000	104.125
16	261.0741714970	255.783578603000		1.00000000	89.528
17	-146.1773704860AS-255.783578603000			-1.00000000	97.453
REFL					
18	261.0997517790AS	255.783578603000		1.00000000	205.856
REFL					
19	0.0000000000	28.735542080900		1.00000000	124.760
20	109.6782509150AS	38.909049290900 SIO2		1.56028895	88.089
21	135.0819403950	<34.026191601900		1.00000000	77.262
22	924.4561476110AS	8.069959863570 SIO2		1.56028895	72.489
23	160.5273775430	10.595882904100		1.00000000	67.277
24	235.8718663040AS	7.500000282500 SIO2		1.56028895	66.691
25	91.9041643509AS	53.294023047800		1.00000000	62.768
26	-205.3313455720AS	10.112177939500 SIO2		1.56028895	67.817
27	181.5659153660AS	36.638050799700		1.00000000	84.020
28	-218.8110282430AS	17.002554642700 SIO2		1.56028895	88.472
29	-306.0771138910	2.194650554950		1.00000000	101.900
30	1012.5233622100AS	70.026755238900 SIO2		1.56028895	124.857
31	-164.6431855120	1.440946030220		1.00000000	130.125
32	2428.6611437000AS	73.814351326800 SIO2		1.56028895	162.607
33	-268.7836036320	5.493021022200		1.00000000	165.580
34	488.5298714750	22.840490084300 SIO2		1.56028895	163.904
35	580.9338597070AS	0.700105164493		1.00000000	162.871
36	187.5425527570	48.105092550200 SIO2		1.56028895	148.849
37	309.0482752900AS	0.700000000000		1.00000000	144.793
38	154.7060357500	52.700158760500 SIO2		1.56028895	125.378
39	487.2890983560AS	0.700109862209		1.00000000	119.143
40	108.8519037810AS	38.999967097200 SIO2		1.56028895	86.389
41	255.7300706450AS	0.700000000028		1.00000000	78.106
42	58.8111563603AS	8.208600134150 SIO2		1.56028895	54.205
43	36.0000000000	0.200000000000 IMM		1.56100000	36.000
44	35.5270708244	47.858381827100 SAPHIR		1.92803200	35.527
45	0.0000000000	0.000000000000		1.00000000	13.000

Table 7 A

ASPHERIC CONSTANTS

SURFACE NR. 1		SURFACE NR. 5	
K	0.000000000000	K	0.000000000000
C1	1.86059361768e-007	C1	-9.53421881016e-008
C2	4.05057017192e-011	C2	-1.03844971388e-010
C3	-1.31841572067e-014	C3	2.32054024129e-014
C4	2.11455178287e-018	C4	-2.55893960085e-018
C5	-1.37550363215e-022	C5	1.46964131542e-022
C6	-3.0654848572e-027	C6	-5.68168161656e-027
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 2		SURFACE NR. 7	
K	0.000000000000	K	0.000000000000
C1	2.24682809077e-007	C1	-1.42410844113e-007
C2	-3.80408550218e-013	C2	3.63573091706e-011
C3	-5.07763034577e-015	C3	-3.59181355360e-015
C4	8.78051550397e-019	C4	3.88098016915e-019
C5	-3.18680606332e-023	C5	-7.68689276860e-022
C6	-8.78627241886e-027	C6	1.36306743838e-025
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 3		SURFACE NR. 8	
K	0.000000000000	K	0.000000000000
C1	3.08843746784e-008	C1	1.82920529853e-007
C2	-1.63321292542e-011	C2	3.21137729148e-011
C3	2.56349264518e-015	C3	1.67685051231e-015
C4	-1.58876710814e-019	C4	4.42833608238e-019
C5	4.77752939064e-024	C5	-5.21173870061e-022
C6	1.23800518289e-027	C6	1.01042894894e-025
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 4		SURFACE NR. 12	
K	0.000000000000	K	0.000000000000
C1	1.07709071403e-007	C1	-1.09760181303e-008
C2	2.81021734141e-011	C2	8.99330099331e-013
C3	-8.15414861895e-016	C3	2.07163843123e-017
C4	4.62084903826e-019	C4	-1.45949776651e-021
C5	-5.11359978782e-024	C5	-7.59048793631e-027
C6	4.23529675830e-027	C6	6.78605969949e-031
C7	0.00000000000e+000	C7	0.00000000000e+000
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000

SURFACE NR. 14

K	0.000000000000
C1	3.68587285688e-009
C2	8.03420920687e-013
C3	-2.41712300553e-017
C4	2.07350539074e-021
C5	-4.32523648446e-026
C6	8.09494371326e-031
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 20

K	0.000000000000
C1	3.07330350059e-009
C2	3.51299446462e-013
C3	-2.73096011107e-017
C4	7.53235543248e-021
C5	-5.51768568282e-025
C6	4.77403823132e-029
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 15

K	0.000000000000
C1	1.14142103559e-007
C2	5.38434133214e-013
C3	3.63169684499e-017
C4	3.00299527459e-021
C5	-7.77924941038e-026
C6	1.73446531567e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 22

K	0.000000000000
C1	3.73843386108e-008
C2	2.42848115213e-012
C3	-9.69703374779e-016
C4	3.36358677040e-019
C5	-3.68962417533e-023
C6	1.70287625834e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 17

K	-0.130103822401
C1	1.51920737571e-008
C2	5.22604911334e-013
C3	2.59906899521e-018
C4	1.63390676191e-021
C5	-7.55562058166e-026
C6	3.26060344061e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 24

K	0.000000000000
C1	-7.89532696153e-008
C2	1.31890077992e-011
C3	-3.76703391800e-015
C4	-1.09246682182e-018
C5	2.62589383473e-022
C6	-1.51931245274e-026
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 18

K	-0.337383833302
C1	4.20663807019e-010
C2	5.30791743228e-015
C3	3.12683337206e-020
C4	1.14513963911e-024
C5	-1.22569865540e-029
C6	2.15298250643e-034
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 25

K	0.000000000000
C1	2.60931514972e-008
C2	2.51002823061e-011
C3	-3.21559778683e-015
C4	-1.33762959057e-018
C5	1.72420265055e-022
C6	4.07836656337e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 26

K	0.000000000000
C1	1.03539135151e-008
C2	-1.16928750430e-011
C3	-3.73401954915e-015
C4	6.94086715792e-019
C5	-8.72530972529e-023
C6	5.60584760968e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 32

K	0.000000000000
C1	-6.25892500858e-010
C2	-1.36988090673e-014
C3	-9.26633392978e-020
C4	-6.32699253504e-025
C5	2.00230743996e-027
C6	-4.26768706269e-032
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 27

K	0.000000000000
C1	2.25456278813e-008
C2	-1.08400561429e-011
C3	-4.50684319751e-015
C4	1.09796369033e-018
C5	-1.01874753749e-022
C6	3.70973359868e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 35

K	0.000000000000
C1	-1.08959324605e-008
C2	7.24998109883e-014
C3	-7.82840684501e-018
C4	-2.81131614820e-022
C5	1.42546937787e-026
C6	-1.52188651619e-031
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 28

K	0.000000000000
C1	-2.36838070001e-008
C2	4.98343064034e-012
C3	1.78215458358e-016
C4	9.85666857804e-022
C5	-7.70745734815e-026
C6	8.05694832124e-029
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 37

K	0.000000000000
C1	-2.80186987842e-009
C2	-2.05383027167e-013
C3	-1.55866356601e-018
C4	-8.89189354781e-023
C5	5.35867582708e-027
C6	9.12022739781e-032
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 30

K	0.000000000000
C1	-3.85494020143e-008
C2	3.54826973931e-013
C3	-1.49388026004e-017
C4	-1.35039738322e-022
C5	2.90800216333e-026
C6	-1.62600691982e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 39

K	0.000000000000
C1	7.8347440861e-009
C2	1.40055971213e-013
C3	1.00311924761e-016
C4	-6.35254246763e-021
C5	2.65703273552e-025
C6	-4.14720963970e-030
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 40

K	0.000000000000
C1	7.46127188025e-008
C2	5.67967381528e-013
C3	4.17445504105e-016
C4	2.57082159937e-021
C5	9.18165436064e-025
C6	3.30686900059e-028
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 41

K	0.000000000000
C1	1.25881731383e-007
C2	1.23553315215e-012
C3	4.54918020734e-016
C4	-1.63322327917e-020
C5	-1.95435442503e-024
C6	-1.52319096577e-028
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 42

K	0.000000000000
C1	-1.20018996760e-007
C2	-2.10066510146e-011
C3	-3.78177102896e-015
C4	-6.06882898398e-019
C5	6.74996127002e-023
C6	2.11373972091e-027
C7	0.00000000000e+000
C8	0.00000000000e+000
C9	0.00000000000e+000

Table 72
SHS2035

Nr	SF	RV	RENV	2*RVMax	Def[mu]	29	Z16	Z25	Z36	Z49	Z64	Z81	Z100
1:	1	188.94	141.31	132.80	982.0	660.48	-27.25	-12.55	-0.29	-1.470	-0.0290	0.00000	0.000000
2:	2	-694.10	-310.18	132.72	612.2	-441.77	82.07	11.44	3.35	1.328	0.0827	0.00000	0.000000
3:	3	84.81	84.75	146.07	52.7	-14.57	32.69	23.06	1.84	0.662	0.0385	-0.00075	-0.000063
4:	4	-139.92	-109.23	137.98	1789.3	-1122.23	-269.80	-46.42	-8.71	-0.791	-0.0651	0.00027	0.000017
5:	5	991.12	-645.57	136.00	1679.7	-1130.72	-12.02	21.89	-10.13	0.582	-0.0749	0.00000	0.000000
6:	7	561.45	126.85	126.73	-229.69	-30.57	-4.38	14.97	5.273	0.6767	0.00000	0.000000	0.000000
7:	8	188.77	344.09	124.03	1454.0	-946.11	-131.28	-20.00	-9.61	-2.938	-0.3664	0.00000	0.000000
8:	12	296.49	293.38	233.48	361.7	226.20	92.62	-12.43	-1.97	0.172	0.0173	0.00000	0.000000
9:	14	170.27	163.16	240.38	713.0	458.23	101.12	8.09	1.35	-0.266	-0.0024	-0.00361	-0.000269
10:	15	952.50	-530.85	211.38	4543.7	-3012.97	-166.17	-23.70	-1.28	0.020	-0.0134	0.00000	0.000000
11:	17	-146.18	-154.88	194.91	540.1	356.25	37.31	3.55	0.38	0.030	0.0071	0.00005	0.000003
12:	18	-261.10	-273.84	411.71	1307.3	829.82	173.55	32.91	5.82	0.937	0.1285	0.01549	0.01146
13:	20	109.68	109.04	179.91	76.7	49.25	12.13	3.19	0.70	0.057	0.0012	-0.00375	-0.000306
14:	22	924.46	594.22	150.88	522.5	341.24	51.73	10.11	0.43	-0.109	0.0959	0.00000	0.000000
15:	24	235.87	315.63	136.97	901.7	-575.18	-133.15	-11.57	6.42	0.152	-0.2210	0.00000	0.000000
16:	25	-91.90	-90.37	126.92	78.8	-7.97	71.75	15.41	-4.50	-1.032	-0.0166	0.00040	0.000029
17:	26	-205.33	-181.02	134.17	653.2	-416.11	-109.56	-1.78	1.16	0.009	0.0611	0.00000	0.000000
18:	27	-181.57	-214.29	160.36	1129.9	754.56	122.15	-34.39	-0.01	1.406	-0.4904	0.00000	0.000000
19:	28	-218.81	-234.75	170.68	696.9	419.02	162.59	14.14	1.91	0.319	0.0255	0.00000	0.000000
20:	30	1012.52	36911.71	229.65	1567.6	-1042.47	-7.39	-8.40	-0.92	-0.261	-0.0328	0.00000	0.000000
21:	32	2428.66	2636.47	300.93	86.8	-58.82	9.88	4.93	0.28	-0.201	-0.0379	0.00000	0.000000
22:	35	-580.93	-960.21	311.89	2562.9	1684.12	216.34	12.53	-9.29	-0.264	0.2550	0.00000	0.000000
23:	37	-309.05	-335.64	290.07	895.0	603.76	63.59	23.21	-7.82	-1.133	-0.0485	0.00000	0.000000
24:	39	-487.29	-377.21	244.77	1659.7	-1063.94	-231.94	-20.60	-0.98	-0.590	0.2043	0.00000	0.000000
25:	40	108.85	100.56	178.68	771.4	572.59	39.64	4.88	-4.27	-2.024	-0.6384	-0.19717	-0.008993
26:	41	-255.73	-176.91	166.09	1591.2	-1072.00	-24.86	16.01	6.07	0.656	0.0330	0.00000	0.000000
27:	42	58.81	60.03	110.98	253.7	-130.26	55.04	38.29	13.36	3.241	0.5905	0.07998	0.007016

Table 8

Shs2037				INDEX 193.304nm	1/2	DIAM
SURFACE	RADIUS	THICKNESS	MATERIAL			
0	0.0000000000	15.810079552000		1.00000000	52.000	
1	194.2935381300AS	16.591815204300	SIO2	1.56028895	67.574	
2	599.2678445640AS	2.473711578570		1.00000000	67.809	
3	123.3563381410AS	15.001953129100	SIO2	1.56028895	71.950	
4	121.8236169490AS	3.806346505350		1.00000000	69.340	
5	82.6748539660AS	24.540486183000	SIO2	1.56028895	72.939	
6	138.0435204550AS	33.844485536400		1.00000000	69.312	
7	736.5751676460AS	24.435244066800	SIO2	1.56028895	68.955	
8	-147.908878950	1.46807249530		1.00000000	69.749	
9	619.0079534330AS	16.326286757900	SIO2	1.56028895	65.448	
10	-194.6423369760AS	31.039821568900		1.00000000	63.961	
11	0.0000000000	60.200321556900		1.00000000	53.505	
12	-64.0607429593	27.672266151600	SIO2	1.56028895	60.343	
13	-81.8994655402	0.700006899642		1.00000000	76.677	
14	300.5543810080AS	40.732384742000	SIO2	1.56028895	115.616	
15	-701.1892029950	0.785236438990		1.00000000	116.355	
16	171.0611545630AS	80.474599206900	SIO2	1.56028895	119.977	
17	-952.2103040220AS	74.278789447300		1.00000000	106.915	
18	261.1730320490	255.679935727000		1.00000000	90.205	
19	-146.0778111080AS-255.	679935727000		-1.00000000	96.734	
REFL						
20	261.1730320490AS	255.679935727000		1.00000000	205.667	
REFL						
21	0.0000000000	28.155114662200		1.00000000	124.101	
22	107.8029883010AS	39.129136084100	SIO2	1.56028895	87.416	
23	126.6127023030	32.978448966500		1.00000000	75.756	
24	678.1222765790AS	7.747058572880	SIO2	1.56028895	71.667	
25	153.1345348420	10.845550065800		1.00000000	66.710	
26	222.0626041440AS	7.561632762300	SIO2	1.56028895	66.165	
27	91.0487371180AS	53.450515344400		1.00000000	62.593	
28	-210.2033721970AS	9.541566794310	SIO2	1.56028895	68.085	
29	182.2045733180AS	36.701106495500		1.00000000	83.677	
30	-218.8990245680AS	17.036468896300	SIO2	1.56028895	88.122	
31	-309.5664444770	2.224258751360		1.00000000	101.829	
32	1031.9633187400AS	70.238501206000	SIO2	1.56028895	124.916	
33	-164.433032990	1.861034823470		1.00000000	130.193	
34	2976.9968593000AS	75.107873726000	SIO2	1.56028895	162.498	
35	-265.3917616970	5.701896462110		1.00000000	165.855	
36	513.4199596720	22.853974648100	SIO2	1.56028895	164.253	
37	616.1533487820AS	0.700002451923		1.00000000	163.272	
38	186.0855698410	48.359084978500	SIO2	1.56028895	148.755	
39	304.7433296040AS	0.700000029556		1.00000000	144.657	
40	154.6107905080AS	52.735369452500	SIO2	1.56028895	125.465	
41	484.3905957550AS	0.700000000065		1.00000000	119.213	
42	108.9325471700AS	39.093034673800	SIO2	1.56028895	86.718	
43	257.1050752120AS	0.700000000380		1.00000000	78.362	
44	58.5242862716AS	8.064267877490	SIO2	1.56028895	54.011	
45	37.0000000000	0.200000000000	IMM	1.56100000	37.000	
46	35.7672894016	47.937581141300	SAPHIR	1.92803200	35.767	
47	0.0000000000	0.000000000000		1.00000000	13.000	

Table 8A

ASPHERIC CONSTANTS

SURFACE NR. 1		SURFACE NR. 5	
K	0.000000000000	K	0.000000000000
C1	1.52182763898e-007	C1	7.59148457617e-009
C2	4.24809796452e-011	C2	-1.80215106466e-011
C3	-1.44295707455e-014	C3	3.38958506925e-015
C4	2.38277641890e-018	C4	-1.84290846470e-019
C5	-1.66893393445e-022	C5	-2.31445731822e-023
C6	-3.49842235826e-027	C6	7.81157255294e-027
C7	2.80879323580e-031	C7	-4.12124997105e-031
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 2		SURFACE NR. 6	
K	0.000000000000	K	0.000000000000
C1	2.07422919342e-007	C1	1.61817304740e-007
C2	1.38162113780e-012	C2	2.08867647801e-011
C3	-5.54862074439e-015	C3	-4.63692402231e-018
C4	6.87559406824e-019	C4	5.40354655370e-019
C5	8.60124142716e-023	C5	3.87822181008e-023
C6	-2.47367492302e-026	C6	1.86998126066e-028
C7	7.20120427263e-031	C7	9.31747340946e-032
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 3		SURFACE NR. 7	
K	0.000000000000	K	0.000000000000
C1	4.05494558278e-008	C1	-9.17034086271e-008
C2	1.71194535894e-012	C2	-1.12670816401e-010
C3	7.80239442971e-016	C3	2.27728356757e-014
C4	-1.32359674076e-020	C4	-2.56904468427e-018
C5	-5.92690524210e-024	C5	1.53411065137e-022
C6	3.31101767389e-027	C6	-5.07226742096e-027
C7	2.57626321338e-031	C7	-2.93943409972e-031
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000
SURFACE NR. 4		SURFACE NR. 9	
K	0.000000000000	K	0.000000000000
C1	4.45402219702e-009	C1	-1.55721767088e-007
C2	6.84303103767e-012	C2	4.64105217679e-011
C3	1.97835007511e-015	C3	-3.23552671170e-015
C4	-2.75826461783e-019	C4	1.64704321079e-019
C5	-1.34762459357e-023	C5	-7.84222099542e-022
C6	-1.52795781921e-027	C6	1.44342488486e-025
C7	1.76600445228e-030	C7	1.10578865155e-030
C8	0.00000000000e+000	C8	0.00000000000e+000
C9	0.00000000000e+000	C9	0.00000000000e+000

SURFACE NR. 10

K	0.000000000000
C1	1.62873612582e-007
C2	3.55429302902e-011
C3	1.09995304587e-015
C4	3.16759181854e-019
C5	-5.45588493495e-022
C6	1.14044535432e-025
C7	6.72560203300e-031
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 19

K	-0.124078642688
C1	1.59263594712e-008
C2	5.17933205562e-013
C3	5.10687019487e-018
C4	1.53696239459e-021
C5	-8.19270825987e-026
C6	4.44437653606e-030
C7	-3.99381634148e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 14

K	0.000000000000
C1	-1.02583520080e-008
C2	8.62101570431e-013
C3	2.52617150273e-017
C4	-1.77821214366e-021
C5	-3.61838153901e-026
C6	3.6997855228e-030
C7	-6.72964835287e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 20

K	-0.334751866761
C1	4.25504836259e-010
C2	5.12935210806e-015
C3	4.06630894523e-020
C4	7.71315257357e-025
C5	-3.21454909671e-030
C6	1.03794698087e-034
C7	5.90630815597e-040
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 16

K	0.000000000000
C1	3.01871225460e-009
C2	8.64256452997e-013
C3	-2.20943941443e-017
C4	1.62155795574e-021
C5	3.85565127563e-027
C6	-9.12548831127e-031
C7	6.03548065056e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 22

K	0.000000000000
C1	1.95889815982e-009
C2	1.90950690941e-013
C3	-1.67596486620e-017
C4	3.97308136282e-021
C5	-1.65476547584e-026
C6	-1.02953550293e-029
C7	2.62676701322e-033
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 17

K	0.000000000000
C1	1.10449705662e-007
C2	6.85842701386e-013
C3	4.19788193616e-017
C4	3.22595315304e-021
C5	-1.81253203352e-025
C6	1.31589880877e-029
C7	-1.85153915252e-034
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 24

K	0.000000000000
C1	3.00346174150e-008
C2	1.01567816642e-012
C3	-8.41093683088e-016
C4	3.44567825340e-019
C5	-3.51270721176e-023
C6	1.24599172791e-027
C7	3.34365288294e-032
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 26

K	0.000000000000
C1	-9.58302401144e-008
C2	1.83907475529e-011
C3	-3.54912600401e-015
C4	-1.24336076571e-018
C5	2.33183759371e-022
C6	-9.34466285683e-027
C7	-1.94663561010e-031
C8	0.00000000000e+000
C9	0.00000000000e+000

C9 0.00000000000e+000

K	0.000000000000
C1	-3.84351735665e-008
C2	3.57796213684e-013
C3	-1.36694485987e-017
C4	-6.23150437979e-023
C5	2.34877803839e-026
C6	-1.56652695896e-030
C7	1.06172810900e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 27

K	0.000000000000
C1	-4.25221078555e-009
C2	2.65084566155e-011
C3	-3.00865415952e-015
C4	-1.16738927967e-018
C5	5.05891961004e-023
C6	2.13721959869e-026
C7	-8.83523197621e-031
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 32

K	0.000000000000
C1	-6.56830430275e-010
C2	-1.45753876332e-014
C3	-1.37902933975e-019
C4	-1.91648562126e-024
C5	2.0210344011e-027
C6	-4.33600228644e-032
C7	9.12790371661e-038
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 28

K	0.000000000000
C1	2.17234988260e-008
C2	-1.3699547540e-011
C3	-3.17632279806e-015
C4	6.81029382890e-019
C5	-7.78327852134e-023
C6	4.19803398784e-027
C7	9.44775674860e-032
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 34

K	0.000000000000
C1	-6.56830430275e-010
C2	-1.45753876332e-014
C3	-1.37902933975e-019
C4	-1.91648562126e-024
C5	2.0210344011e-027
C6	-4.33600228644e-032
C7	9.12790371661e-038
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 29

K	0.000000000000
C1	2.62642047061e-008
C2	-9.81419464212e-012
C3	-4.55036921427e-015
C4	1.08147487200e-018
C5	-1.02047434407e-022
C6	3.97968712547e-027
C7	-1.43310787576e-032
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 37

K	0.000000000000
C1	-1.08694129766e-008
C2	7.33753920405e-014
C3	-7.79938334817e-018
C4	-2.79943871022e-022
C5	1.41988595194e-026
C6	-1.56064111184e-031
C7	1.63994569589e-037
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 30

K	0.000000000000
C1	-2.66765769286e-008
C2	5.40155188970e-012
C3	1.54518633501e-016
C4	2.79510693226e-021
C5	-2.16525005908e-025
C6	3.48924429453e-029
C7	4.18617804812e-033
C8	0.00000000000e+000

SURFACE NR. 39

K	0.000000000000
C1	-2.74995147218e-009
C2	-2.04259498199e-013
C3	-1.51365186640e-018
C4	-8.81355353262e-023
C5	5.24995776852e-027
C6	1.00205162500e-031
C7	1.56229882160e-037
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 40

K	0.000000000000
C1	-2.62325914220e-010
C2	-4.64364714236e-015
C3	1.27823808984e-018
C4	-5.19175820062e-023
C5	-3.08090505916e-027
C6	7.16374159432e-032
C7	1.11953280752e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 44

K	0.000000000000
C1	-1.14201791905e-007
C2	-1.93083955912e-011
C3	-2.96305450551e-015
C4	-9.55272113449e-019
C5	2.64110397113e-022
C6	-4.57222488195e-026
C7	4.83104261929e-030
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 41

K	0.000000000000
C1	7.81918075824e-009
C2	1.38023573338e-013
C3	9.99233116072e-017
C4	-6.36105773586e-021
C5	2.70762174262e-025
C6	-4.06755279655e-030
C7	-1.99740574495e-035
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 42

K	0.000000000000
C1	7.24747559240e-008
C2	3.57433450714e-013
C3	4.10186245339e-016
C4	-6.14667957577e-022
C5	1.44698262019e-024
C6	2.65410265038e-028
C7	4.61556982659e-033
C8	0.00000000000e+000
C9	0.00000000000e+000

SURFACE NR. 43

K	0.000000000000
C1	1.25110570297e-007
C2	1.53034565013e-012
C3	4.68948451357e-016
C4	-1.41311581924e-020
C5	-1.87641445601e-024
C6	-2.65050647206e-028
C7	7.88781238216e-033
C8	0.00000000000e+000
C9	0.00000000000e+000

Table 82
SHS2037

Nr	sf	RV	RENV	2*HMax	Def [mμ]	29	216	225	249	236	264	281	2100
1:	1	194.29	150.18	131.85	814.6	548.21	-29.97	-12.12	0.19	-1.317	0.0118	0.00278	0.000000
2:	2	-599.27	-327.11	132.27	624.9	-413.30	65.62	5.32	2.16	1.438	0.1083	-0.00749	0.000000
3:	3	123.36	115.70	139.55	483.0	294.49	81.88	24.38	6.41	1.374	0.1563	-0.00623	-0.000005
4:	4	-121.82	-116.29	134.72	386.2	-237.64	-68.69	-11.88	-5.93	-2.202	-0.3517	-0.02461	0.000002
5:	5	82.67	83.15	141.10	85.5	-14.55	56.40	25.63	2.70	0.851	0.0333	-0.00673	0.000443
6:	6	-138.04	-106.32	133.65	1726.8	-1087.89	-252.55	-51.29	-7.83	-0.447	-0.0162	-0.00090	0.000015
7:	7	736.58	-705.37	132.28	1832.1	-1227.19	-66.74	18.75	-8.37	-0.256	-0.0913	-0.0306	0.000000
8:	8	619.01	877.97	125.56	148.2	-103.05	4.36	-1.43	15.67	5.415	0.6962	0.00500	0.000000
9:	9	194.64	342.28	122.87	1334.2	-855.67	-124.44	-21.34	-11.04	-3.228	-0.3946	-0.0215	0.000000
10:	14	300.55	295.99	237.82	397.1	253.38	90.97	-15.65	-1.73	0.402	-0.0035	-0.00835	0.000000
11:	16	171.06	163.13	244.58	679.3	551.88	147.08	20.77	4.94	0.342	0.0828	0.00637	-0.00404
12:	17	952.21	-505.27	217.80	4938.7	-3266.71	-227.38	-36.86	-4.26	-0.513	-0.0421	0.00563	0.000000
13:	19	-146.08	-154.78	193.47	529.2	-349.39	35.33	3.31	0.34	0.029	0.0056	-0.00016	0.000002
14:	20	-261.17	-273.76	411.33	1289.9	817.80	171.36	32.43	5.73	0.922	0.1276	0.01480	0.001130
15:	22	107.80	107.43	178.35	48.3	29.91	9.18	3.15	0.81	0.132	0.0225	0.00073	-0.000208
16:	24	678.12	512.65	149.50	431.7	274.73	54.97	12.80	0.56	-0.098	0.0988	0.00247	0.000000
17:	26	222.06	293.28	136.14	902.9	-567.60	-143.53	-21.47	5.90	0.540	-0.1730	-0.0321	0.000000
18:	27	-91.05	-90.65	126.85	127.9	30.91	74.05	19.94	-3.72	-1.115	-0.0345	0.00482	0.000008
19:	28	-210.20	-188.38	134.82	576.6	-310.00	-95.44	2.79	1.43	0.033	0.0690	0.00133	0.000000
20:	29	-182.20	-212.10	160.24	1079.8	718.14	128.66	-31.62	-0.47	1.290	-0.4727	0.00321	0.000000
21:	30	-218.90	-233.81	170.44	682.6	410.25	161.63	12.40	1.79	0.368	0.0486	0.00252	0.000000
22:	32	1031.96	64064.32	230.20	1552.0	-1032.93	-1.70	-7.44	-0.76	-0.206	-0.0210	0.00078	0.000000
23:	34	2977.00	3330.52	299.00	98.1	-66.92	7.63	4.80	0.44	-0.139	-0.0286	0.00044	0.000000
24:	37	-616.15	-1029.87	310.22	2367.6	1556.05	195.70	13.11	-8.12	-0.371	0.1907	-0.0143	0.000000
25:	39	-304.74	-328.78	284.69	808.7	543.96	60.17	-18.71	-6.45	-0.962	-0.0462	-0.00035	0.000000
26:	40	154.61	154.67	251.84	10.7	0.42	5.28	2.57	1.22	0.391	0.0597	0.00376	0.000023
27:	41	-484.39	-380.95	240.72	1490.8	-957.75	-204.76	-17.04	-0.14	-0.332	0.00301	0.000000	0.2038
28:	42	108.93	100.90	177.03	745.0	533.61	44.13	10.79	-1.44	-1.155	-0.4406	-0.07823	-0.006942
29:	43	-257.11	-178.88	162.60	1512.5	-1012.96	-33.74	11.78	4.38	0.491	0.0091	-0.0223	0.000000
30:	44	58.52	59.65	109.66	197.9	-106.94	50.45	32.94	11.27	2.706	0.4936	0.06818	0.005742

What is claimed is

1. Projection objective for imaging a pattern provided in an object plane of the projection objective onto an image plane of the projection objective suitable for microlithography projection exposure machines comprising:
 - 5 a plurality of optical elements transparent for radiation at an operating wavelength of the projection objective; wherein at least one optical element is a high-index optical element
 - 10 made from a high-index material with a refractive index $n \geq 1.6$ at the operating wavelength.
2. Projection objective according to Claim 1, wherein the high-index material has a refractive index $n \geq 1.8$ at the operating wavelength.
- 15 3. Projection objective according to Claim 1, wherein the high-index material is sapphire.
4. Projection objective according to Claim 1, wherein the high-index material is germanium dioxide.
- 20 5. Projection objective according to Claim 1, wherein an object-side numerical aperture NA_{Obj} is greater than 0.3.
- 25 6. Projection objective according to Claim 5, wherein the object-side numerical aperture $NA_{Obj} > 0.36$ in conjunction with an absolute reduction ratio of $|\beta| \leq 0.25$.
7. Projection objective according to Claim 1, having a first high-index optical element and at least one second high-index optical element.
- 30

8. Projection objective according to Claim 7, wherein the first high-index optical element and the second high-index optical element are each made from a high-index material exhibiting birefringence defining an orientation of birefringence of each optical element,
5 where the first and second high-index optical elements are installed differently with regard to the orientation of the birefringence such that effects of birefringence caused by the high-index optical elements are at least partly compensated.
- 10 9. Projection objective according to Claim 1, wherein the projection objective has a last optical element closest to the image plane and wherein the last optical element is at least partly made of a high-index material with refractive index $n > 1.6$.
- 15 10. Projection objective according to Claim 9, wherein the last optical element is a monolithic plano-convex lens made of a high-index material with refractive index $n > 1.6$.
- 20 11. Projection objective according to Claim 9, wherein the last optical element consists of at least two optical elements in optical contact with each other along a splitting interface, where at least one of the optical elements forming the last optical element consists of a high-index material with refractive index $n > 1.6$.
- 25 12. Projection objective according to Claim 9, wherein the last optical element consists of an entry side plano-convex lens element having a curved entry side and a planar exit side and an exit side plane parallel plate in optical contact with the plano-convex lens element along a planar splitting surface.
30
13. Projection objective according to Claim 12, wherein the plano-convex lens element consists of a high-index material with a refractive

index $n > 1.6$ and wherein the exit side plane parallel plate consists of fused silica.

14. Projection objective according to Claim 12, wherein the plano-convex lens element consists of fused silica and wherein the exit side plane parallel plate consists of a high-index material with a refractive index $n > 1.6$.
5
15. Projection objective according to Claim 11, wherein the last optical element is shaped as a plano-convex lens and a splitting surface is curved such that both optical elements contacted at the splitting surface are lens parts with similar refractive power.
10
16. Projection objective according to Claim 1, wherein the projection objective is designed as an immersion objective adapted with reference to aberrations such that an image side working distance between a last optical element and the image plane is filled up with an immersion medium with a refractive index substantially greater than 1.
15
17. Projection objective according to Claim 16, wherein the projection objective is adapted to an immersion fluid which has a refractive index greater than 1.4 at the operating wavelength.
20
18. Projection objective according to Claim 17, wherein the projection objective is designed for 193 nm operating wavelength and wherein the immersion fluid is cyclohexane.
25
19. Projection objective according to one Claim 1, wherein the projection objective is designed as a solid immersion objective having a finite image side working distance in the order of the operating wavelength or below such that evanescent fields exiting
30

from an image side exit surface of the projection objective can be used for imaging.

20. Projection objective according to Claim 1, wherein the projection
5 objective is designed for solid immersion lithography where an image side exit surface of the projection objective is in mechanical contact with an incoupling surface associated with a substrate to be exposed.
- 10 21. Projection objective according to Claim 1, wherein an image side numerical aperture NA is greater than 1.3.
22. Projection objective according to Claim 1, wherein a pupil surface positioned closest to the image plane is positioned in a region of
15 convergent beam between a region of a local maximum of beam diameter closest to the image plane and the image plane.
23. Projection objective having an image plane and a lens furthest therefrom and starting from which there is a convergent beam path
20 up to the image plane, in which a pupil plane or system aperture is arranged at a distance of at least 10 mm on the image side of said lens.
24. Microlithography projection exposure method for imaging a pattern provided on a mask positioned in an object plane of a projection objective onto a substrate provided in an image plane of the projection objective, in which a microlithography projection objective according to at least one of the preceding claims is used and an immersion fluid is introduced between a last lens of the
30 microlithography projection objective and the substrate to be exposed.

25. Method according to Claim 24, in which an immersion fluid is used which has a refractive index greater than 1.4 at an operating wavelength of the projection objective.

5 26. Method according to Claim 25, in which the immersion fluid has a refractive index greater than 1.5 at the operating wavelength.

10 27. Microlithography projection exposure method for imaging a pattern provided on a mask positioned in an object plane of a projection objective onto a substrate provided in an image plane of the projection objective, in which an image-side last optical element of a projection objective being used is wrung or pressed onto the object to be exposed comprising the following steps in the given sequence:

15 positioning the projection objective and the substrate to be exposed relative to one another;

contacting the exit surface of the projection objective and an incoupling surface of the substrate;

aligning the mask relative to the projection objective such that a

20 desired pattern region of the mask is imaged onto a target area of the substrate in contact with the exit surface of the projection objective.

25 28. Method according to Claims 27, wherein the steps are repeated for a number of juxtaposed target areas on the substrate.

29. Method according to Claim 27, wherein a thin transparent membrane is placed between the substrate to be exposed and the exit surface of the projection objective.

30

30. Method according to Claim 24, in which a microlithography projection objective according to one of Claims 1 is used.

31. Microlithography projection exposure method for imaging a pattern provided on a mask positioned in an object plane of a projection objective onto a substrate provided in an image plane of the projection

5 objective, in which a microlithography projection objective is used and an immersion fluid is introduced between a last lens of the microlithography projection objective and the substrate to be exposed, wherein Cyclo-hexane is used as immersion fluid.

10 32. Projection objective according to Claim 9, wherein the last optical element includes a plano-convex composite lens having an image-side plano-convex second lens element having a curved entry surface and an essentially planar exit surface, and an object-side first lens element having a curved entry surface and a curved exit surface in optical

15 contact with the curved entry surface of the first lens element, where a first curvature radius R_1 of the curved entry surface of the first lens element is larger than a second curvature radius R_2 of the entry surface of the second lens element.

20 33. Projection objective according to Claim 32, wherein the first lens element has a first refractive index n_1 which is smaller than the second refractive index n_2 of the second lens element such that the condition $\Delta n \geq 0.25$ holds for a refractive index difference $\Delta n = n_2 - n_1$.

25 34. Projection objective according to Claim 32, wherein the second lens element is made from a high-index crystalline material and the first lens element is made from a glassy material.

35. Projection objective according to Claim 34, wherein the crystalline

30 material is chosen from the group consisting of aluminum oxide (Al_2O_3), beryllium oxide (BeO), magnesium aluminum oxide ($MgAlO_4$, spinell),

magnesium oxide (MgO), yttrium aluminum oxide ($Y_3Al_5O_{12}$), yttrium oxide (Y_2O_3) and lanthanum fluoride (LaF_3).

36. Projection objective according to Claim 34, wherein the first lens
5 element is made from silicon dioxide (SiO_2).

37. Projection objective according to Claim 9, wherein the last optical
element includes a plano-convex composite lens having an image-side
plano-convex second lens element having a curved entry surface and an
10 essentially planar exit surface, and an object-side first lens element
having a curved entry surface and a curved exit surface in optical
contact with the curved entry surface of the first lens element, wherein
an immersion medium having refractive index n_l is disposed in a gap
between the exit surface of the first lens element and the entry surface
15 of the second lens element.

38. Projection objective according to Claim 37, wherein the first lens
element has a first refractive index n_1 which is smaller than the second
refractive index n_2 of the second lens element such that the condition Δn
20 ≥ 0.25 holds for a refractive index difference $\Delta n = n_2 - n_1$ and wherein
the immersion medium has a refractive index in the range $1.3 \leq n_l \leq 1.6$.

39. Projection objective according to Claim 37, wherein the gap has a
maximum gap width GW in the range $50 \mu m \leq GW \leq 2 mm$.

25

40. Projection objective according to Claim 9, wherein the last optical
element includes a hyper-hemispherical lens having a curved entry
surface with curvature radius R_2 , an essentially planar exit surface, and
an axial lens thickness T defined as a distance between the entry
30 surface and the exit surface measured along the optical axis of the lens,
where $T > R_2$.

41. Projection objective according to Claim 40, wherein the projection objective has an image-side numerical aperture $1.7 \leq \text{NA} \leq 1.8$

42. Projection objective according to Claim 40, wherein a shape of the 5 hyper-hemispherical lens is a combination of a hemispherical section and a cylindrical section having a radius equal to the radius of curvature of the hemispherical section.

43. Projection objective according to Claim 40, wherein the hyper- 10 hemispherical lens has a spherical entry surface extending spherically beyond a central section plane through the center of curvature of the spherical entry surface and aligned perpendicular to the optical axis of the lens.

15 44. Projection objective according to Claim 40, wherein the hyper- hemispherical lens forms an image-side second lens element of a composite plano-convex last optical element.

45. Projection objective according to Claim 1, wherein the projection 20 objective includes at least one aspheric lens group consisting of a number N_{ASPL} of at least two immediately consecutive aspheric lenses providing a number N_{ASP} of aspheric lens surfaces, where the condition $AR > 1$ holds for an asphere ratio $AR = N_{ASP}/N_{ASPL}$.

25 46. Projection objective according to Claim 45, wherein $N_{ASPL} \geq 3$ and $AR \geq 1,5$

47. Projection objective according to Claim 45, wherein N_{ASPL} is selected from the group comprising 3, 4, 5, 6.

48. Projection objective according to Claim 45, wherein the aspherical lens group includes at least one of three, four, five and six immediately consecutive aspheric surfaces.

5 49. Projection objective according to Claim 45, wherein exactly one spherical surface is present within the aspherical lens group such that the condition $N_{ASP} = 2 \cdot N_{ASPL} - 1$ is fulfilled, where $N_{ASPL} \geq 3$.

10 50. Projection objective according to Claim 49, wherein N_{ASPL} is selected from the group consisting of 3, 4, 5.

15 51. Projection objective according to Claim 9, wherein an image-side aspheric lens group is arranged immediately upstream of the last optical element consisting of a number N_{ASPL} of at least two immediately consecutive aspheric lenses providing a number N_{ASP} of aspheric lens surfaces, where the condition $AR > 1,5$ holds for an asphere ratio $AR = N_{ASP}/N_{ASPL}$.

20 52. Projection objective according to Claim 51, wherein $N_{ASPL} = 2$

53. Projection objective according to Claim 9, wherein at least three immediately consecutive aspheric lens surfaces are provided immediately upstream of the last optical element.

25 54. Projection objective according to Claim 51, wherein the image-side aspheric lens group includes at least two consecutive positive meniscus lenses having a concave lens surface facing the image surface.

30 55. Projection objective according to Claim 1, wherein an object-side aspheric lens group is arranged immediately downstream of the object plane consisting of a number N_{ASPL} of at least two immediately consecutive aspheric lenses providing a number N_{ASP} of aspheric lens

surfaces, where the condition $AR > 1,5$ holds for an asphere ratio $AR = N_{ASP}/N_{ASPL}$.

56. Projection objective according to Claim 55, wherein N_{ASPL} is one of
5 3, 4 and 5.

57. Projection objective according to Claim 55, wherein the object-side
aspheric lens group includes an aspheric lens surface having a vertex
radius of curvature, R_V , on the optical axis and an edge radius of
10 curvature, R_E , at the edge of the lens surface, where $R_E \leq 0,7 \cdot R_V$

58. Projection objective according to Claim 1, having a first, refractive
objective part for imaging the pattern provided in the object plane into a
first intermediate image; a second objective part including at least one
15 concave mirror for imaging the first intermediate image into a second
intermediate image; a third objective part for imaging the second
intermediate image onto the image plane.

59. Projection objective according to Claim 58, where pupil surfaces
20 are formed between the object plane and the first intermediate image,
between the first and the second intermediate image and between the
second intermediate image and the image plane; and wherein at least
one biaspherical lens having an aspheric entry surface and an aspheric
exit surface is positioned between the object surface and a first pupil
25 surface in a region close to the first pupil surface at a distance from that
pupil surface smaller than or equal to a diameter of the pupil at that pupil
surface.

60. Projection objective according to Claim 58, wherein a meniscus
30 group having at least one meniscus lens having an object-side concave
lens surface is arranged immediately downstream of a first pupil surface

in the first objective part, where a thickness of that meniscus lens does not exceed 0,6 times the diameter of the meniscus lens.

61. Projection objective according to Claim 60, wherein aspheric lens surfaces of the meniscus group have local radii of curvature, R_C smaller than 1,2 D, where D is the free diameter of the meniscus lens.
62. Projection objective according to Claim 58, wherein a lens group immediately upstream of the first intermediate image has at least one lens having an entry side radius of curvature R_1 and an entry side radius of curvature R_2 defining a mean radius of curvature $R_m = 1/(1/R_1 + 1/R_2)$, where the mean radius of curvature has a center on the image-side of the lens.
63. Projection objective according to Claim 58, wherein a lens group immediately upstream of the first intermediate image includes at least one biaspherical lens.
64. Projection objective according to Claim 58, wherein a lens group immediately downstream of the second intermediate image includes at least one positive meniscus lens having an image-side concave lens surface.
65. Projection objective according to Claim 58, wherein the third objective part includes a negative lens group between the second intermediate image and an image-side pupil surface having at least three consecutive aspheric lens surfaces.
66. A projection objective for imaging a pattern provided in an object plane of the projection objective onto an image plane of the projection objective comprising:

a plurality of optical elements transparent for radiation at an operating wavelength of the projection objective and including a plurality of aspheric lenses having at least one aspheric lens surface,

where an aspheric lens surface is represented by Zernike coefficients K_i

5 and Zernike polynomials Z_i according to

$$p(h) = \frac{h^2}{R(1 + \sqrt{1 - \frac{h^2}{R^2}})} + K_0 + K_4 \cdot Z_4 + K_9 \cdot Z_9 + K_{16} \cdot Z_{16} + K_{25} \cdot Z_{25} +$$

$$K_{36} \cdot Z_{36} + K_{49} \cdot Z_{49} + K_{64} \cdot Z_{64} + K_{81} \cdot Z_{81} + K_{100} \cdot Z_{100}$$

10 where the sagitta p of a point on an aspherical surface is represented as a function of a normalized radial distance h from the optical axis and the radius R of the aspheric lens surface is fixed such that $K_4=0$, where

$$Z_4 = 2 \cdot h^2 - 1$$

15

$$Z_9 = 6 \cdot h^4 - 6 \cdot h^2 + 1$$

$$Z_{16} = 20 \cdot h^6 - 30 \cdot h^4 + 12 \cdot h^2 - 1$$

$$20 \quad Z_{25} = 70 \cdot h^8 - 140 \cdot h^6 + 90 \cdot h^4 - 20 \cdot h^2 + 1$$

$$Z_{36} = 252 \cdot h^{10} - 630 \cdot h^8 + 560 \cdot h^6 - 210 \cdot h^4 + 30 \cdot h^2 - 1$$

$$Z_{49} = 924 \cdot h^{12} - 2772 \cdot h^{10} + 3150 \cdot h^8 - 1680 \cdot h^6 + 420 \cdot h^4 - 42 \cdot h^2 + 1$$

25

$$Z_{64} = 3432 \cdot h^{14} - 12012 \cdot h^{12} + 16632 \cdot h^{10} - 11550 \cdot h^8 + 4200 \cdot h^6 - 756 \cdot h^4 + 56 \cdot h^2 - 1$$

$$Z_{81} = 12870 \cdot h^{16} - 51480 \cdot h^{14} + 84084 \cdot h^{12} - 72072 \cdot h^{10} + 34650 \cdot h^8 - 9240 \cdot h^6 + 1260 \cdot h^4 - 72 \cdot h^2 + 1$$

$$Z100 = 48620 \cdot h^{18} - 218790 \cdot h^{16} + 411840 \cdot h^{14} - 420420 \cdot h^{12} + 252252 \cdot h^{10} - 90090 \cdot h^8 + 18480 \cdot h^6 - 1980 \cdot h^4 + 90 \cdot h^2 - 1$$

and where the normalized radius h with $0 < h \leq 1$ is defined as :

5
$$h = \frac{\text{distance from optical axis}}{1/2 \text{ lens diameter of the aspheric surface}} ;$$

a last optical element arranged closest to the image plane, where the last optical element has refractive power and a refractive index n_{LOE} ;
an image-side numerical aperture NA; and

10 a geometrical aperture $\sin \alpha$ within the last optical element;
wherein the projection objective is used at high image-side numerical aperture $NA \geq 1,3$ in an optical limit range where the aperture $\sin \alpha$ within the last optical element corresponding to the ratio NA / n_{LOE} obeys the condition

15

$$\sin \alpha \geq 0,8.$$

67. Projection objective according to claim 66, wherein $NA \geq 1,4$ and $\sin \alpha \geq 0,9$.

20

68. Projection objective according to claim 66, wherein an object-side aspheric lens group formed by lenses immediately downstream of the object plane has at least three immediately consecutive aspheric lens surfaces and a first surface of that object-side aspheric lens group
25 closest to the object plane observes at least one of the following conditions:

$$-14 \geq K9/K16 \geq -25$$

$$+ 2 \leq K16/K25 \leq 8.$$

30

69. Projection objective according to claim 68, wherein a second aspheric surface following the first aspheric surface of the object-side aspheric lens group obeys at least one of the following conditions:

$$\begin{aligned} 5 & -3,5 \geq K9/K16 \geq -7,5 \\ & +7 \leq K16/K25 \leq +25. \end{aligned}$$

70. Projection objective according to claim 66, wherein an object-side aspheric lens group formed by lenses immediately downstream of the object plane includes at least four immediately consecutive aspheric lens surfaces and at least one of the following conditions holds for a fourth aspheric lens surface following the first, second and third aspheric lens surface:

15 $3 \leq K9/K16 \leq 5$
5 $\leq K9/K16 \leq 15$.

71. Projection objective according to claim 66, wherein an object-side aspheric lens group formed by lenses immediately downstream of the object plane has one of three, four, five and six immediately consecutive aspheric lens surfaces, and a surface curvature at the vertex is oriented such that the local radius of curvature has its center on the image-side for all the aspheric lens surfaces.

25 72. Projection objective according to claim 66, wherein an object-side aspheric lens group formed by lenses immediately downstream of the object plane has one of three, four, five and six immediately consecutive aspheric lens surfaces, and a center of curvature of an envelope sphere to an aspheric surface is on the image-side for all the aspheric lens surfaces of the object-side aspheric lens group.

73. Projection objective according to claim 66, wherein a second lens group is defined as the lens group starting with the first lens surface having the center of curvature on the object-side and at least one of the center of curvature of the first aspheric surface of the second group and

5 the second aspheric lens surface of that second group lies on the object-side.

74. Projection objective according to claim 73, wherein the shape of a first asphere of the second group obeys the following condition:

10

$$9 \leq K9/K16 \leq 20.$$

75. Projection objective according to claim 66, wherein a lens group including negative lenses and designed to form a constriction of the

15 beam diameter between the object plane and the image plane has a first aspheric lens surface obeying at least one of the following conditions:

$$3 \leq K9/K16 \leq 5$$

$$3 \leq K16/K25 \leq 5.$$

20

76. Projection objective according to claim 66, wherein a lens group including negative lenses and designed to form a constriction of the beam diameter between the object plane and the image plane includes at least three and at most five consecutive aspheric lens surfaces and at

25 least one of the following condition holds:
a first aspheric lens surface of that group obeys at least one of the following conditions:

$$-3 \geq K9/K25 \geq -5$$

30 $+5 \leq K16/K25 \leq +7;$

a second aspheric lens surface of that lens group obeys at least one of the following conditions:

$$0,3 \leq K9/K16 \leq 0,5$$

5 3,0 ≤ K16/K25 ≤ 5,0;

a third aspheric lens surface of that lens group obeys at least one of the following conditions:

$$10 \qquad \qquad 3 \leq K9/K16 \leq 5$$

$$-25 \geq K_{16}/K_{25} \geq -40$$

a fourth aspheric lens surface of that lens group obeys at least one of the following conditions:

15

+5 ≤ K9/K16 ≤ +7

$$-3 \leq K_{16}/K_{25} \leq -5;$$

a fifth aspheric lens surface of that lens group obeys at least one of the

20 following conditions:

$$2,0 \leq K9/K16 \leq 3$$

10,0 ≤ K16/K25 ≤ 15,0

25 77. Projection objective according to claim 66, wherein a lens group immediately upstream of a last optical element is primarily or exclusively composed of positive lenses and a first aspheric lens surface on a positive lens of this lens group obeys at least one of the following conditions:

30

$$500 \leq K9/K16 \leq 700$$

$$0,2 \leq K_{16}/K_{25} \leq 0,3.$$

78. Projection objective according to claim 77, wherein a second aspheric lens surface following the first aspheric surface obeys at least one of the following conditions:

5

$$\begin{aligned} -7,0 &\geq K9/K16 \geq -10,0 \\ 1,3 &\leq K16/K25 \leq 1,8. \end{aligned}$$

79. Projection objective according to claim 66, wherein a lens group 10 immediately upstream of a last optical element includes an aspheric lens surface in the region of maximum beam diameter which obeys at least one of the following conditions:

15 $6 \leq K9/K16 \leq 9$
 $12 \leq K16/K25 \leq 17.$

80. Projection objective according to claim 66, wherein a lens group 20 immediately upstream of a last optical element includes at least three and at most five consecutive aspheric lens surfaces in the region of a convergent beam and a first aspheric lens surface of that lens group obeys at least one of the following conditions:

25 $7,0 \leq K9/K16 \leq 12$
 $-2,5 \geq K16/K25 \geq 5,0.$

81. Projection objective according to claim 66, wherein at least one of a third aspheric lens surface of a lens group immediately upstream of the last optical element and a penultimate aspheric lens surface of that lens group obeys at least one of the following conditions:

30

$$\begin{aligned} 3 &\leq K9/K16 \leq 5 \\ 10 &\leq K16/K25 \leq 15. \end{aligned}$$

82. Projection objective according to claim 66, wherein at least one of a last aspheric surface of a lens group immediately upstream of the last optical element and a last aspheric surface of the projection objective upstream the image plane obeys at least one of the following conditions:

5

$$+25 \leq K9/K16 \leq 40$$

$$-2 \geq K16/K25 \geq -4.$$

83. Projection objective according to claim 66, wherein a last aspheric

10 lens surface of the projection objective upstream the image plane obeys at least one of the following conditions:

$$-1,8 \leq K9/K16 \leq 2,5$$

$$+1,3 \leq K16/K25 \leq 1,7$$

15

$$+2,5 \leq K25/K36 \leq 4,0$$

$$+3,5 \leq K36/K49 \leq 5,0$$

$$+4,5 \leq K49/K64 \leq 7,0.$$

83. Projection objective according to claim 66, wherein the projection

20 objective is designed to generate at least one real intermediate image.

84. Projection objective according to claim 83, wherein the projection

is designed to generate at least two real intermediate images.

25

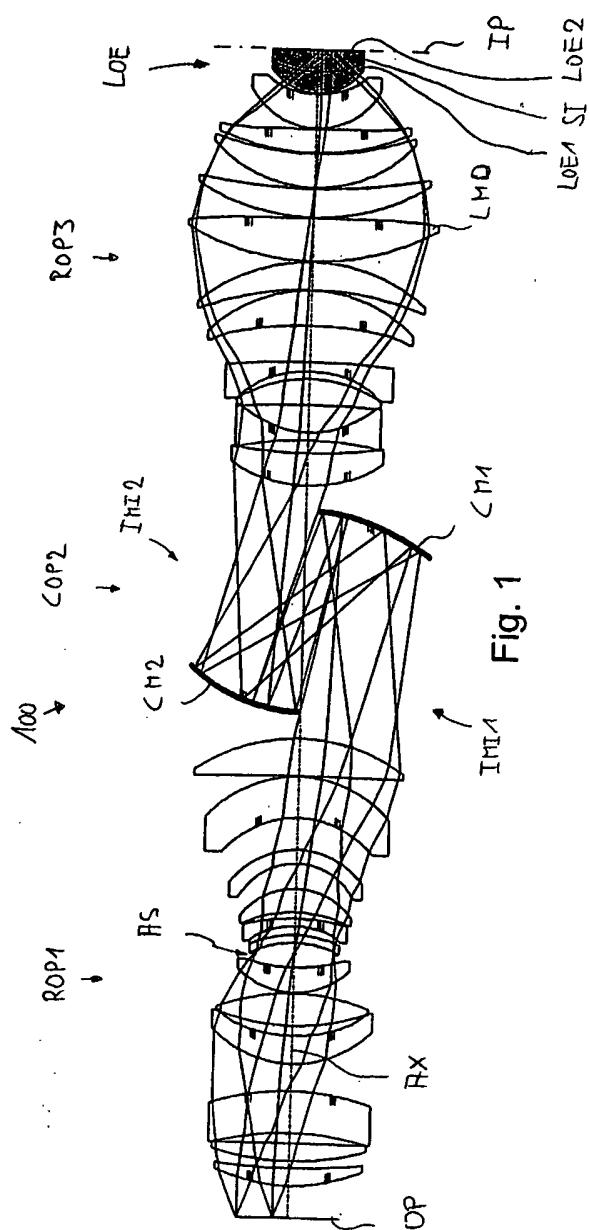
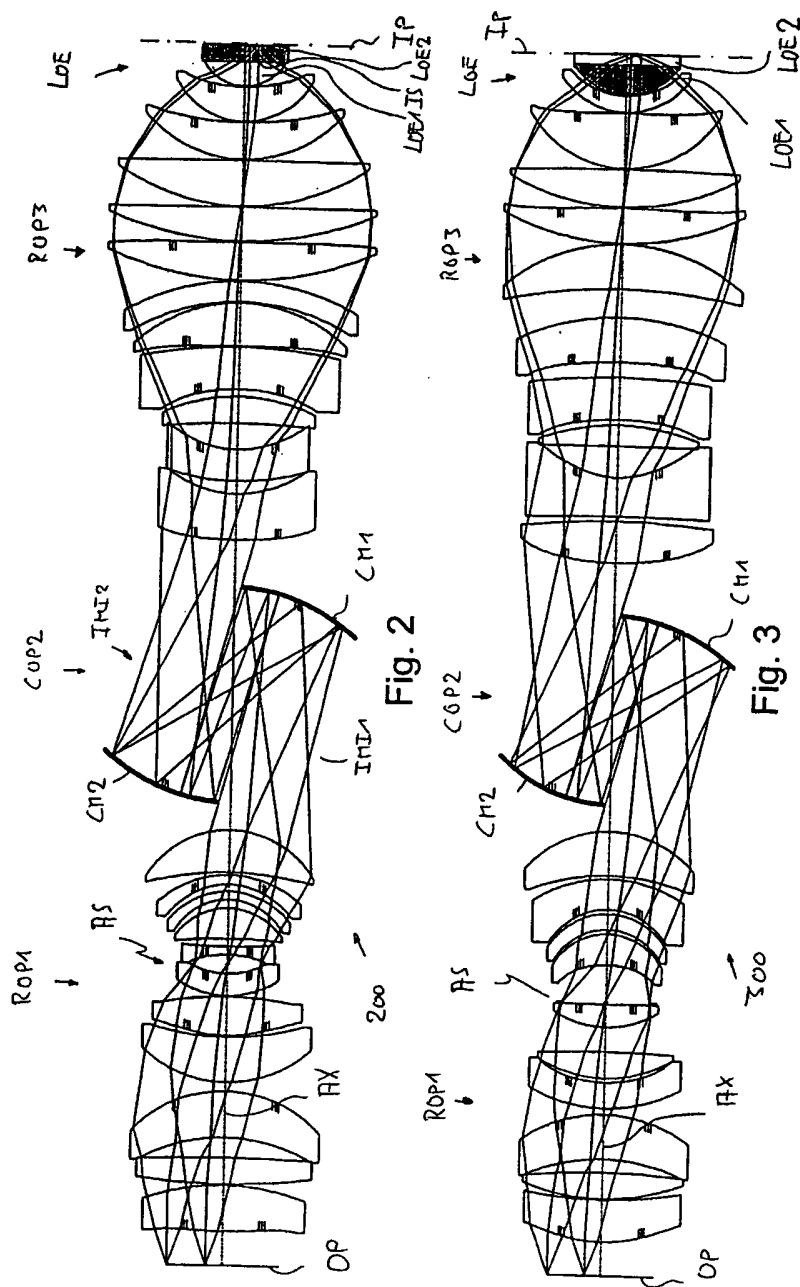
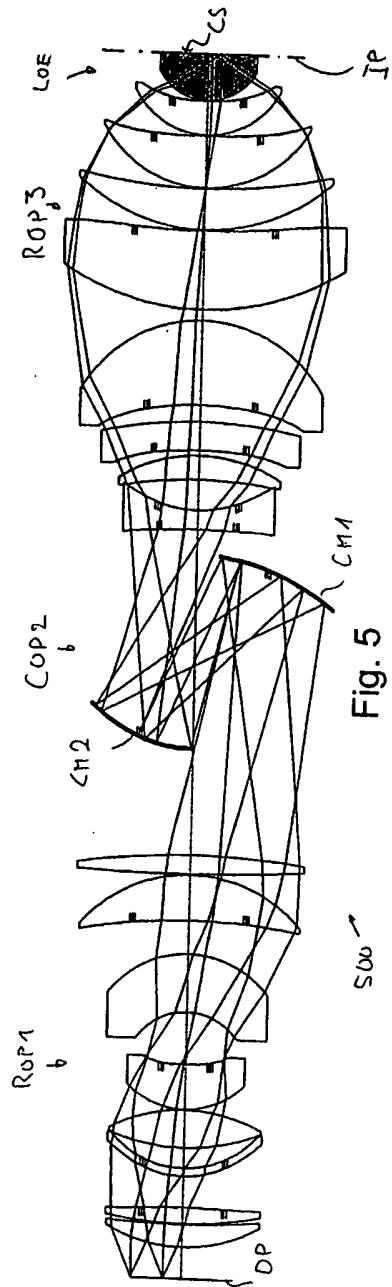
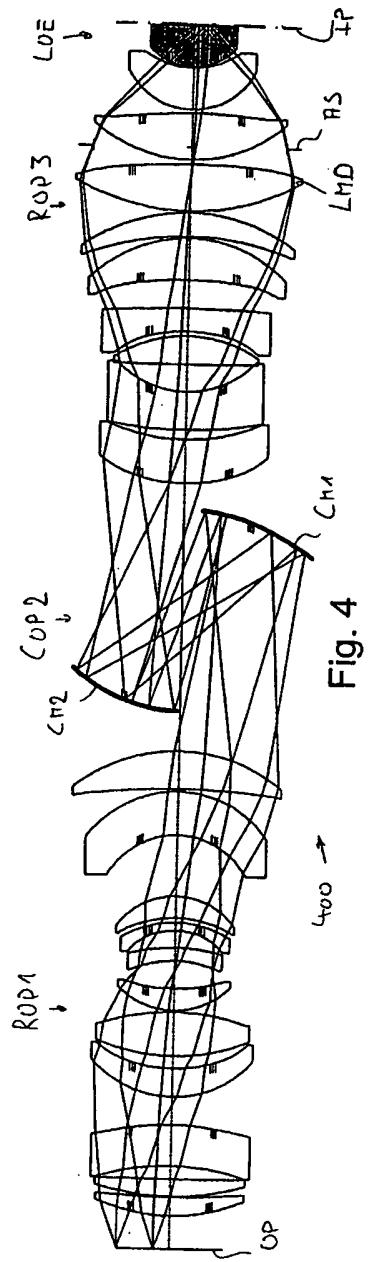


Fig. 1





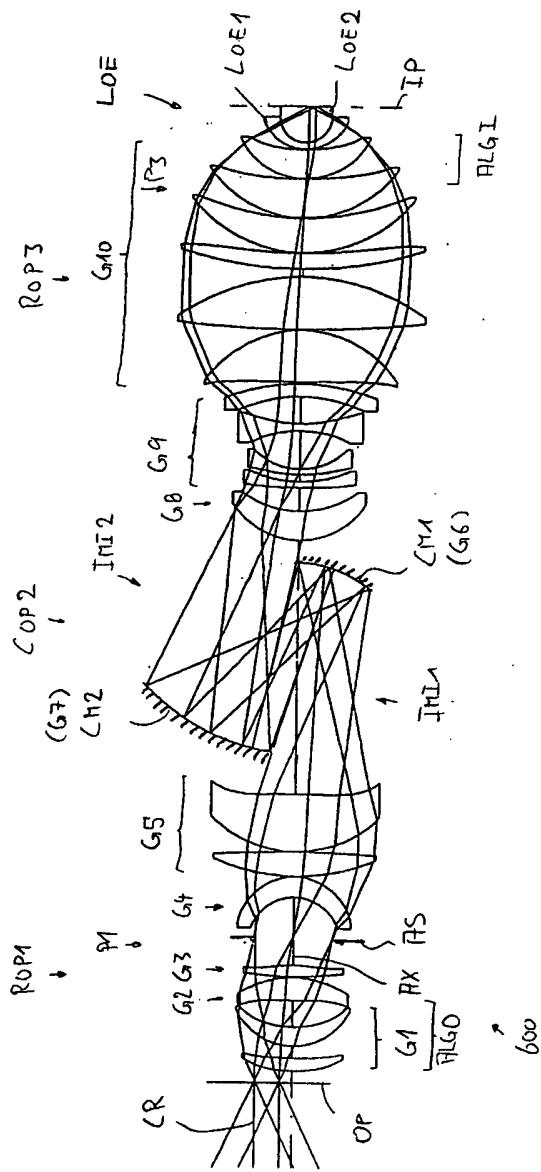


Fig. 6

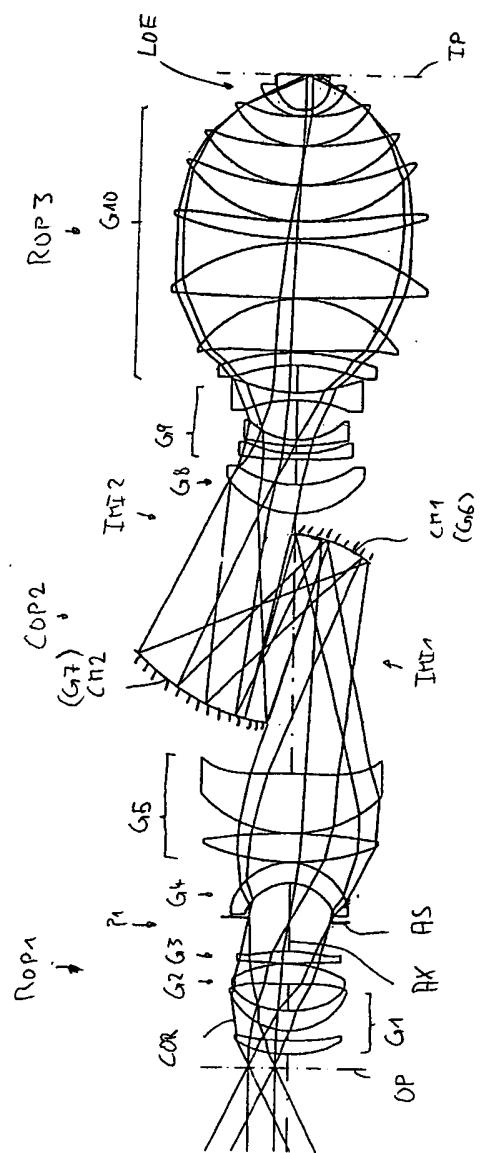


Fig. 7

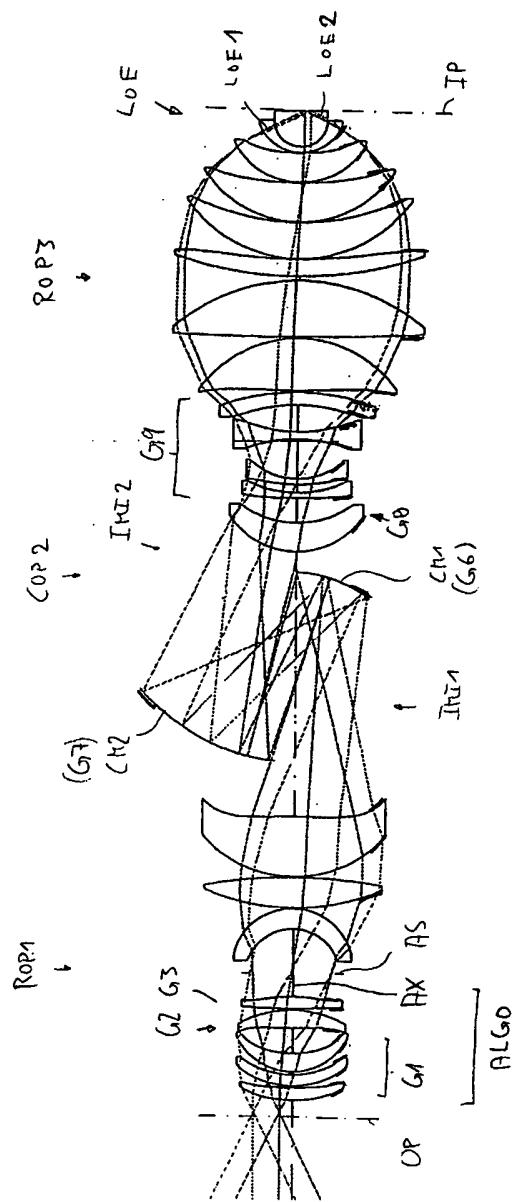


Fig. 8

800

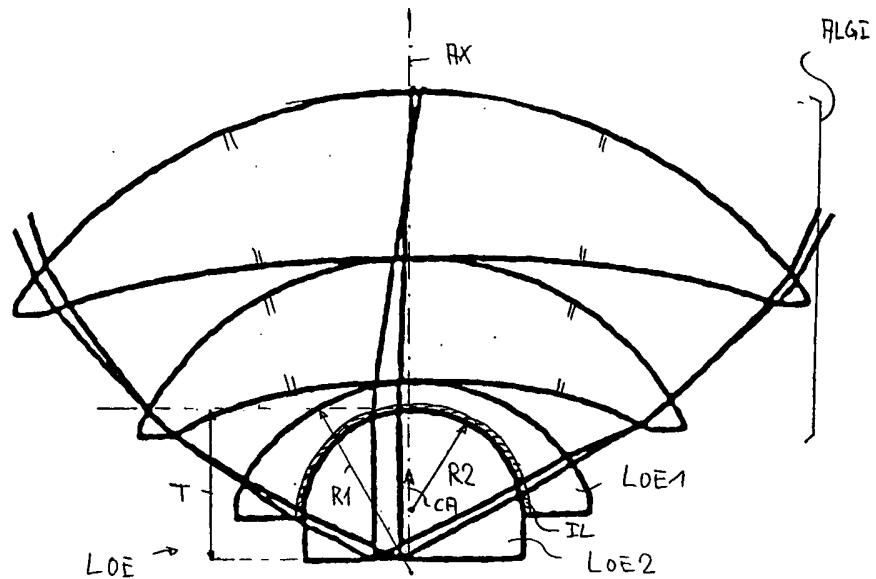


Fig. 9

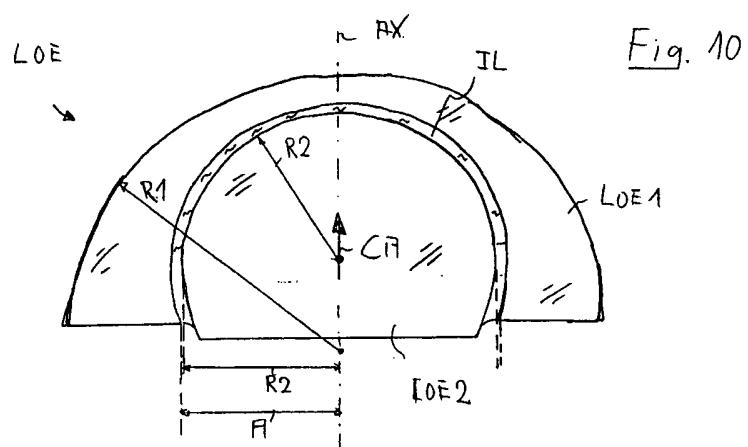


Fig. 10

INTERNATIONAL SEARCH REPORT

International application No
PCT/EP2006/005079

A. CLASSIFICATION OF SUBJECT MATTER
INV. G03F7/20

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
G03F H01L G02B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 6 064 516 A (SCHUSTER ET AL) 16 May 2000 (2000-05-16) abstract figure 2 column 3, lines 11-15 column 2, lines 17-21	1,4,6,7
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X	EP 1 089 327 A (NIKON CORPORATION) 4 April 2001 (2001-04-04) paragraph [0001] figure 1 table 1	23
-/-		

Further documents are listed in the continuation of Box C.

See patent family annex.

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Date of the actual completion of the international search

Date of mailing of the international search report

13 September 2006

02/10/2006

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Menck, Alexander

INTERNATIONAL SEARCH REPORT

International application No
PCT/EP2006/005079

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